

# Simulating Losses in Resonant MEMS

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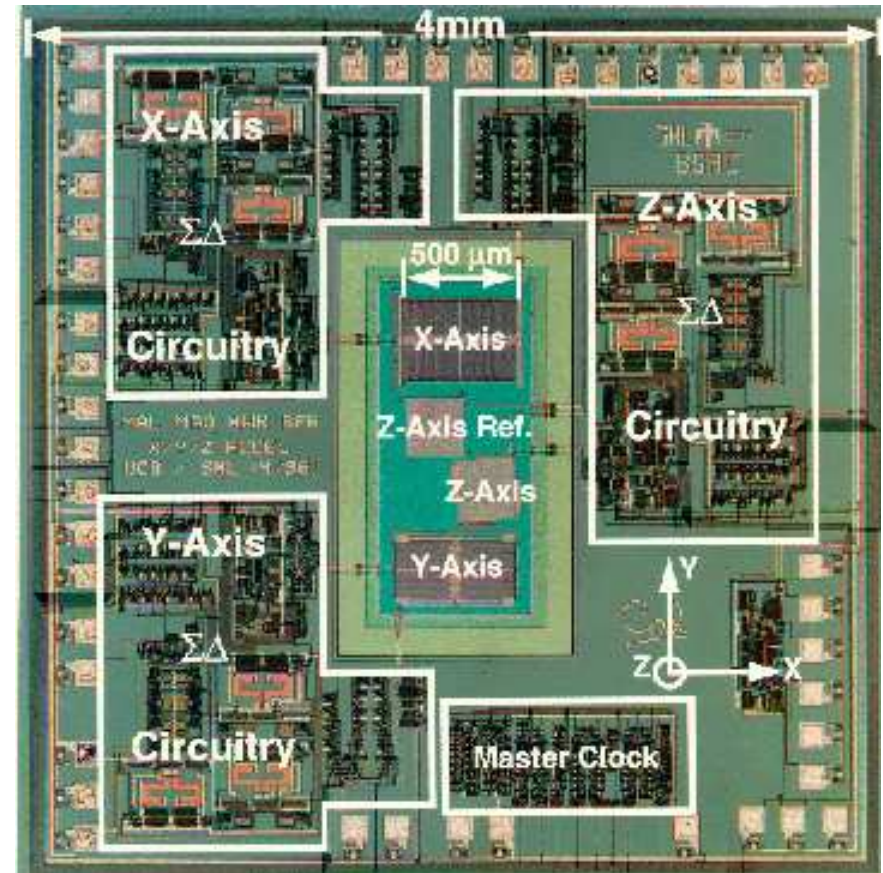
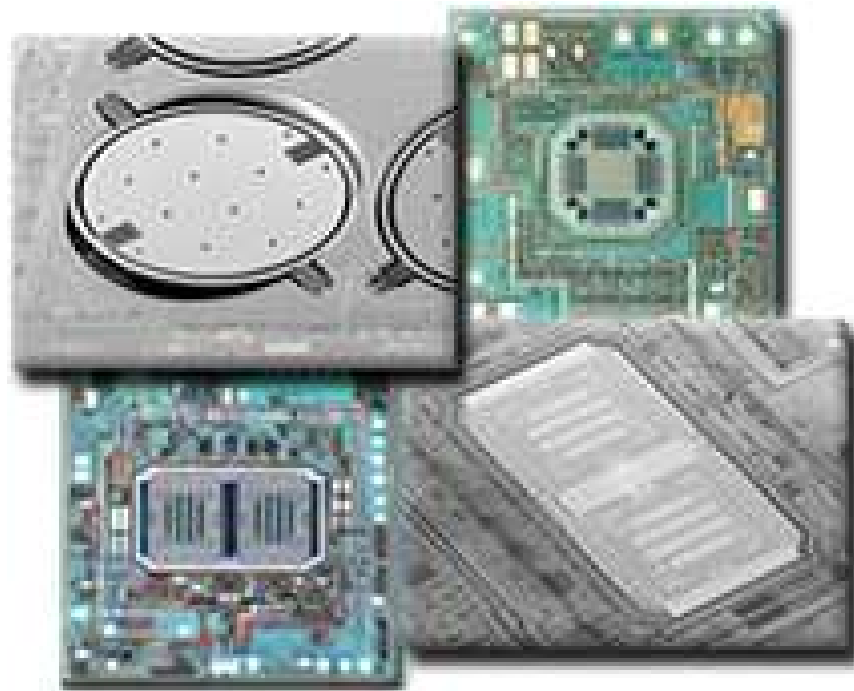
# Outline

- Electromechanical resonators and RF MEMS
- Damping and quality of resonance
- Anchor losses and Perfectly Matched Layers
- Analysis of the discretized PMLs
- Complex symmetry and structured model reduction
- Analysis of a disk resonator
- Conclusions

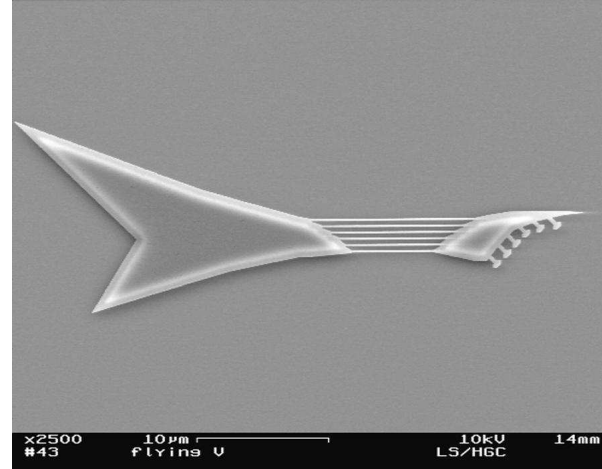
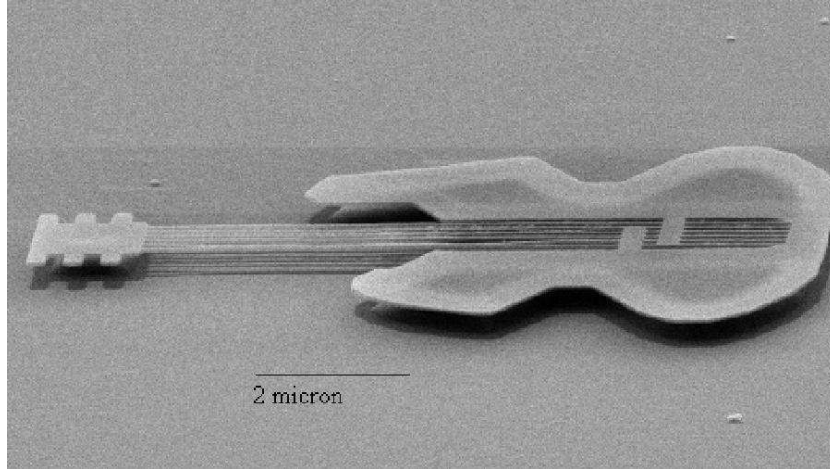
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# How many MEMS?



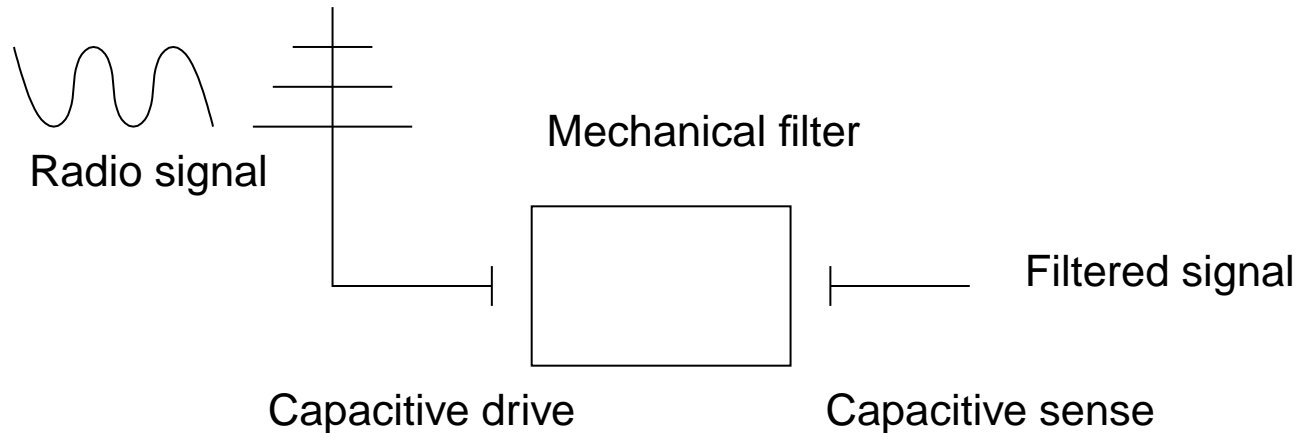
# Why resonant MEMS?



Microguitars from Cornell University (1997 and 2003)

- Sensing elements (inertial, chemical)
- Frequency references
- Filter elements
- Neural networks
- Really high-pitch guitars

# Micromechanical filters



- Mechanical high-frequency (high MHz-GHz) filter
  - Your cell phone is mechanical!
- Advantage over quartz surface acoustic wave filters
  - Integrated into chip
  - Low power

Success  $\implies$  “Calling Dick Tracy!”

# Designing transfer functions

Time domain:

$$\begin{aligned}Mu'' + Cu' + Ku &= b\phi(t) \\ y(t) &= p^T u\end{aligned}$$

Frequency domain:

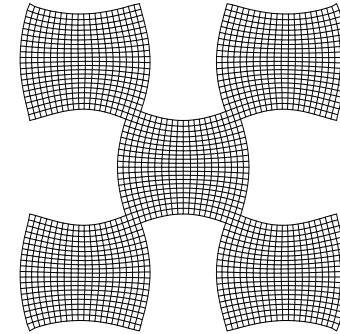
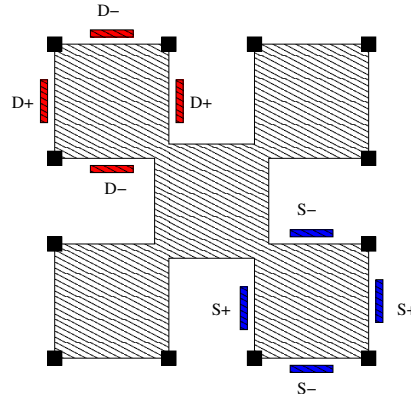
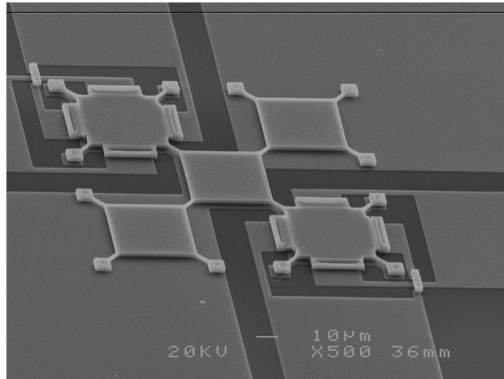
$$\begin{aligned}-\omega^2 M\hat{u} + i\omega C\hat{u} + K\hat{u} &= b\hat{\phi}(\omega) \\ \hat{y}(\omega) &= p^T \hat{u}\end{aligned}$$

Transfer function:

$$\begin{aligned}H(\omega) &= p^T (-\omega^2 M + i\omega C + K)^{-1} b \\ \hat{y}(\omega) &= H(\omega) \hat{\phi}(\omega)\end{aligned}$$

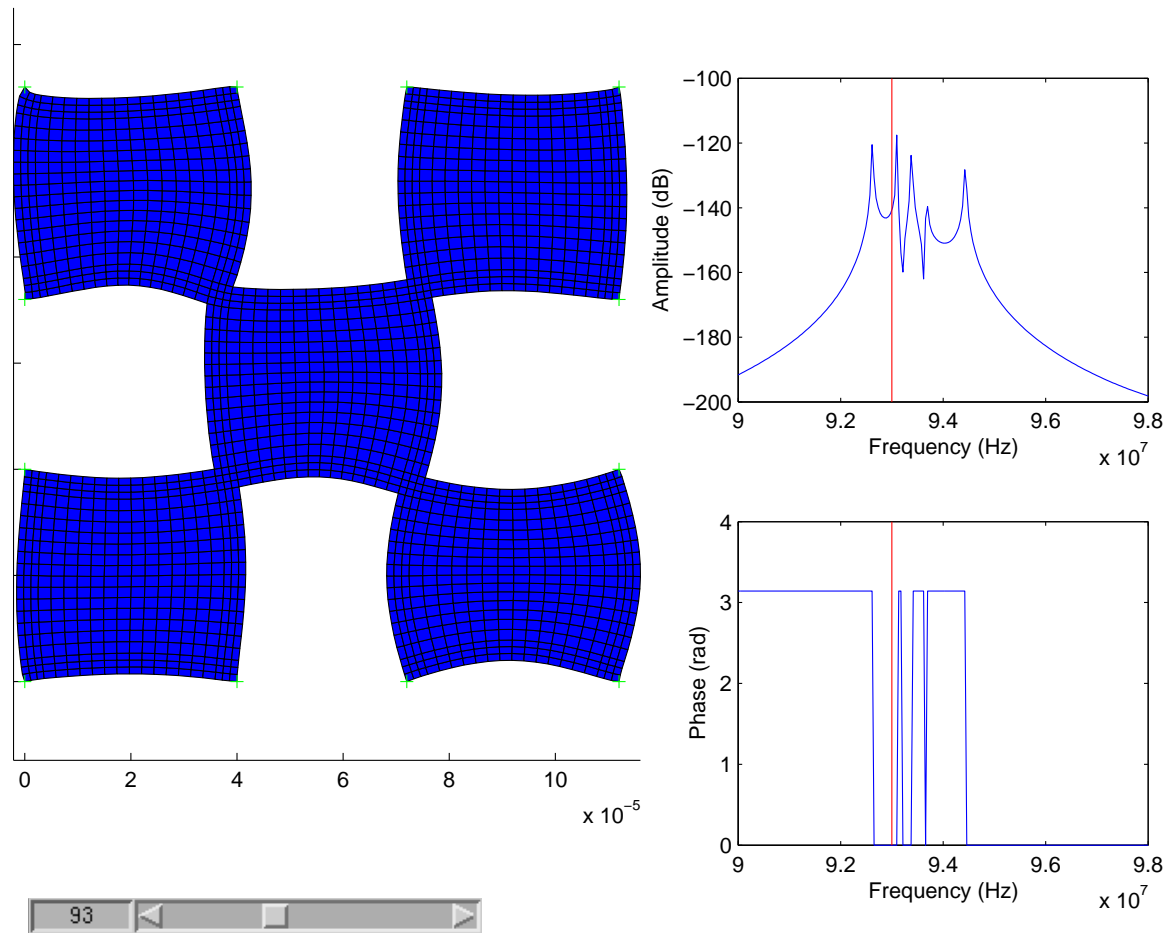


# Checkerboard resonator

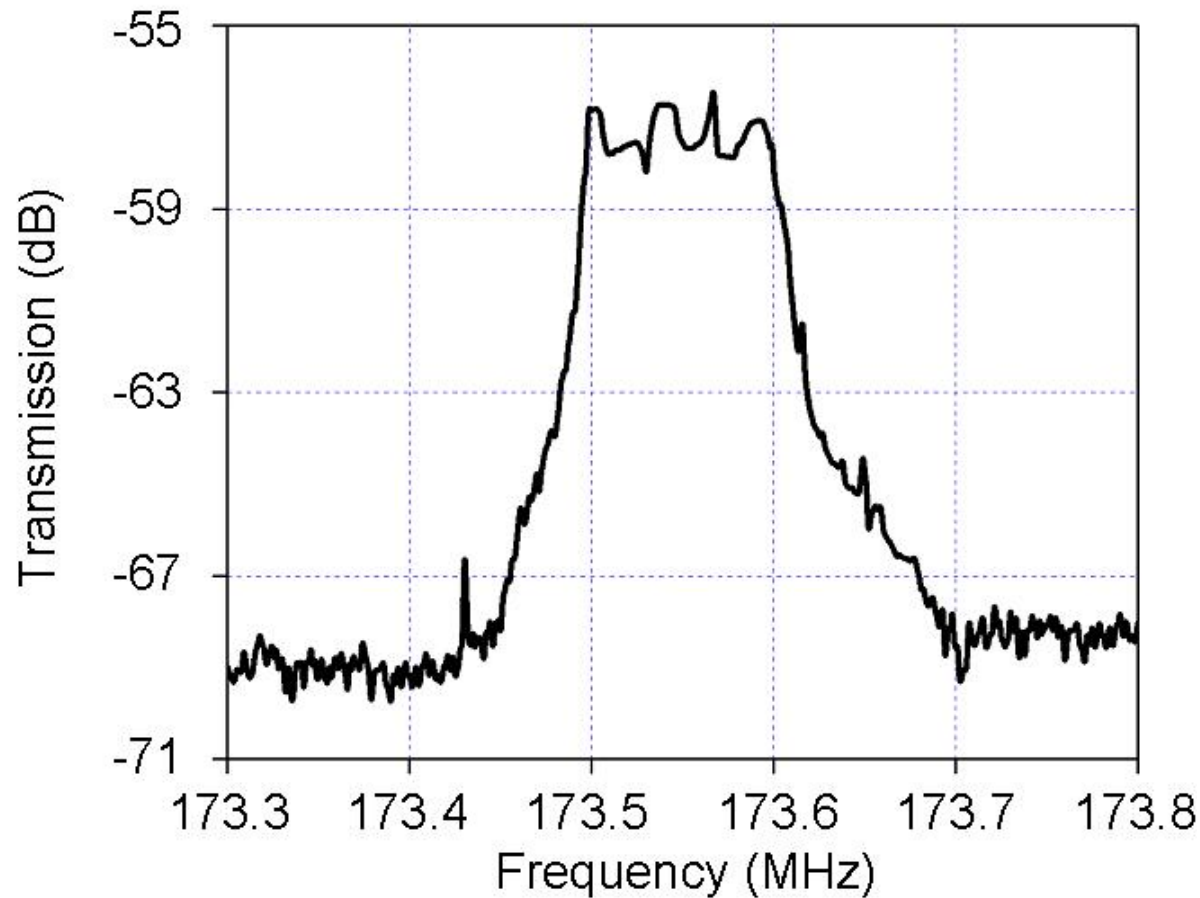


- Array of loosely coupled resonators
- Anchored at outside corners
- Excited at **northwest** corner
- Sensed at **southeast** corner
- Surfaces move only a few nanometers

# Checkerboard simulation

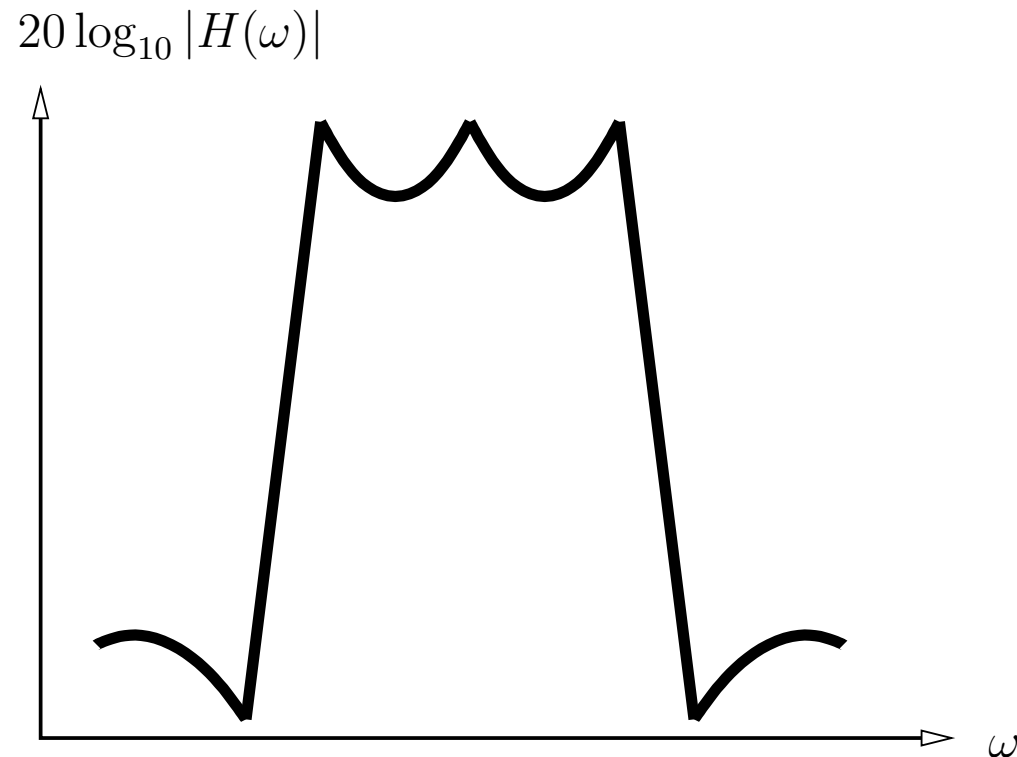


# Checkerboard measurement



S. Bhawe, MEMS 05

# Damping and filters



- Want “sharp” poles for narrowband filters
- $\implies$  Want to minimize damping
  - Electronic filters have too much
  - Understanding of damping in MEMS is lacking

# Damping and $Q$

- Designers want high *quality of resonance* ( $Q$ )
  - Dimensionless damping in a one-dof system:

$$\frac{d^2 u}{dt^2} + Q^{-1} \frac{du}{dt} + u = F(t)$$

- For a resonant mode with frequency  $\omega \in \mathbb{C}$ :

$$Q := \frac{|\omega|}{2 \operatorname{Im}(\omega)} = \frac{\text{Stored energy}}{\text{Energy loss per radian}}$$

# Sources of damping

- Fluid damping
  - Air is a viscous fluid ( $Re \ll 1$ )
  - Can operate in a vacuum
  - Shown not to dominate in many RF designs
- Material losses
  - Low intrinsic losses in silicon, diamond, germanium
  - Terrible material losses in metals
- Thermoelastic damping
  - Volume changes induce temperature change
  - Diffusion of heat leads to mechanical loss
- Anchor loss
  - Elastic waves radiate from structure

# Sources of damping

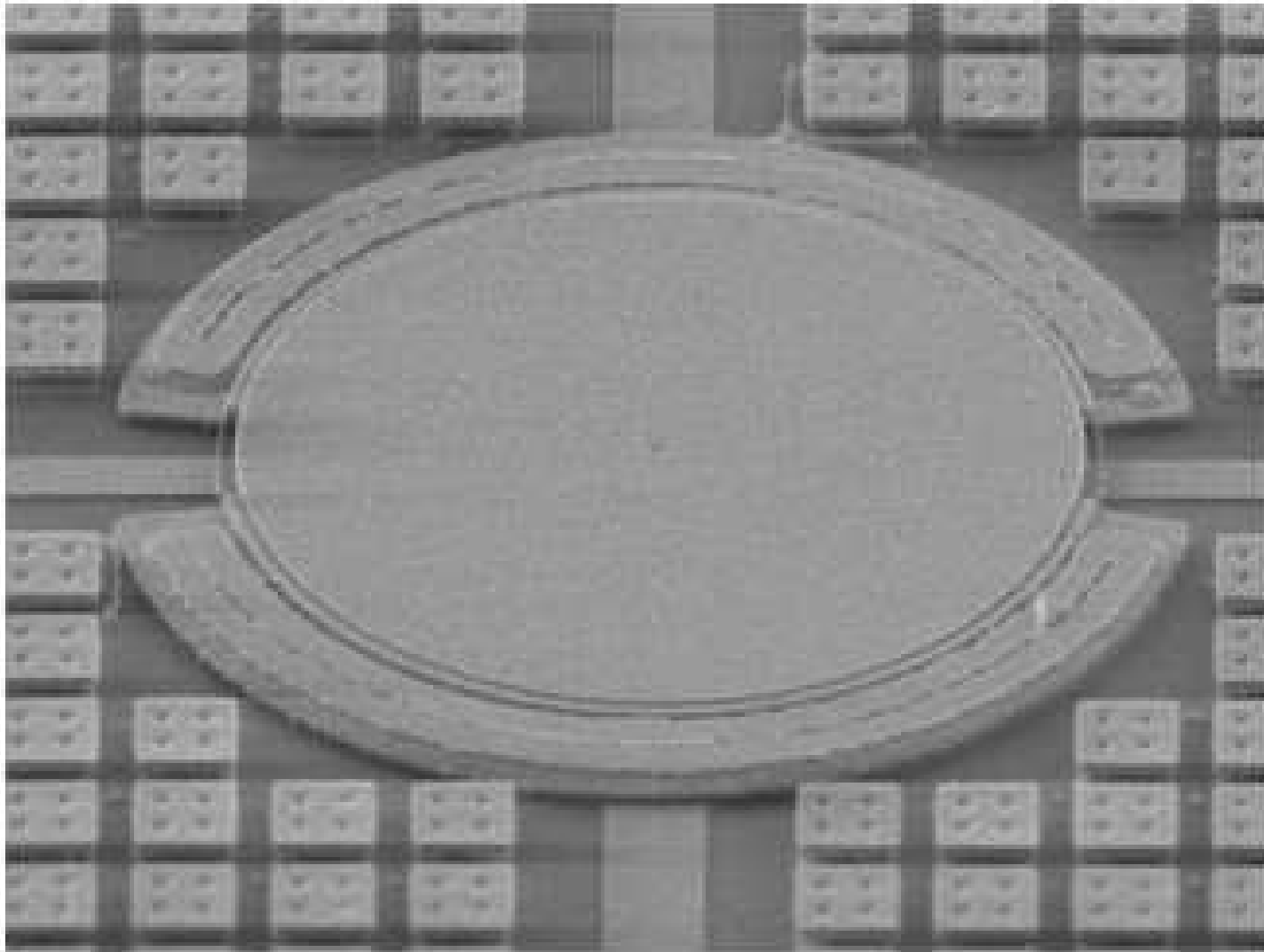
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- Electromechanical resonators and RF MEMS
- Damping and quality of resonance
- Anchor losses and Perfectly Matched Layers
  - Anchor losses and infinite domains
  - Idea of the perfectly matched layer
  - Elastic PMLs and finite elements
- Analysis of the discretized PMLs
- Complex symmetry and structured model reduction
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- Conclusions



# Example: Disk resonator



SiGe disk resonators built by E. Quévy

# Substrate model

Goal: Understand energy loss in disk resonator

- Dominant loss is elastic radiation from anchor
- Resonator size  $\ll$  substrate size
  - Substrate appears semi-infinite
- Possible semi-infinite models
  - Matched asymptotic modes
  - Dirichlet-to-Neumann maps
  - Boundary dampers
  - Higher-order local ABCs
  - Perfectly matched layers

# Perfectly matched layers

- Apply a complex coordinate transformation
- Generates a non-physical absorbing layer
- No impedance mismatch between the computational domain and the absorbing layer
- Idea works with general linear wave equations
  - First applied to Maxwell's equations (Bereng r 95)
  - Similar idea earlier in quantum mechanics (*exterior complex scaling*, Simon 79)
  - Applies to elasticity in standard FEM framework (Basu and Chopra, 2003)

# 1-D model problem

- Domain:  $x \in [0, \infty)$

- Governing eq:

$$\frac{\partial^2 u}{\partial x^2} - \frac{1}{c^2} \frac{\partial^2 u}{\partial t^2} = 0$$

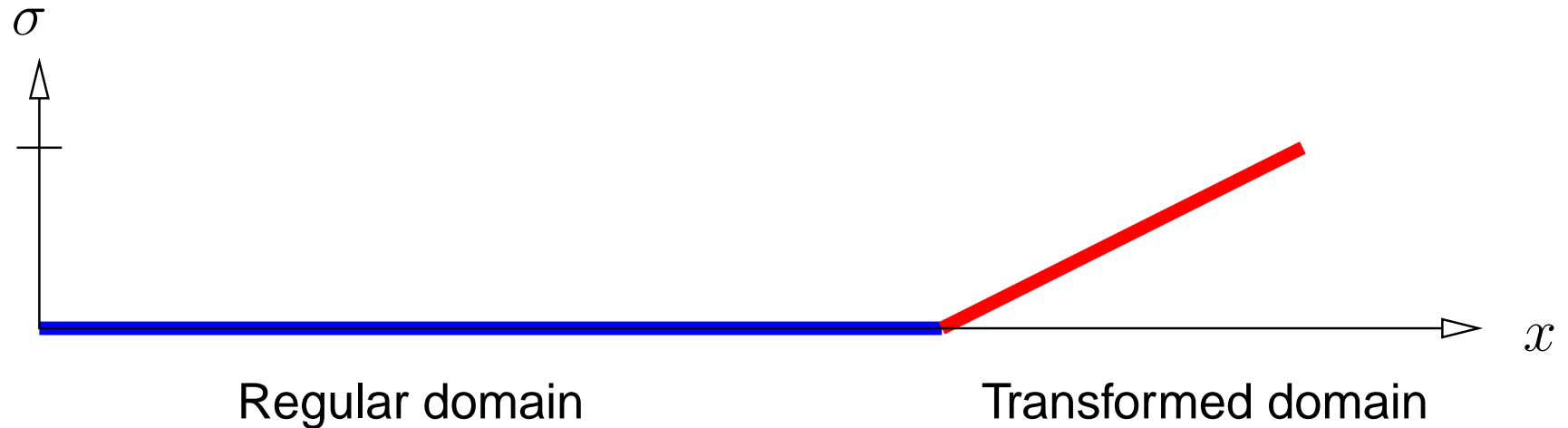
- Fourier transform:

$$\frac{d^2 \hat{u}}{dx^2} + k^2 \hat{u} = 0$$

- Solution:

$$\hat{u} = c_{\text{out}} e^{-ikx} + c_{\text{in}} e^{ikx}$$

# 1-D model problem with PML

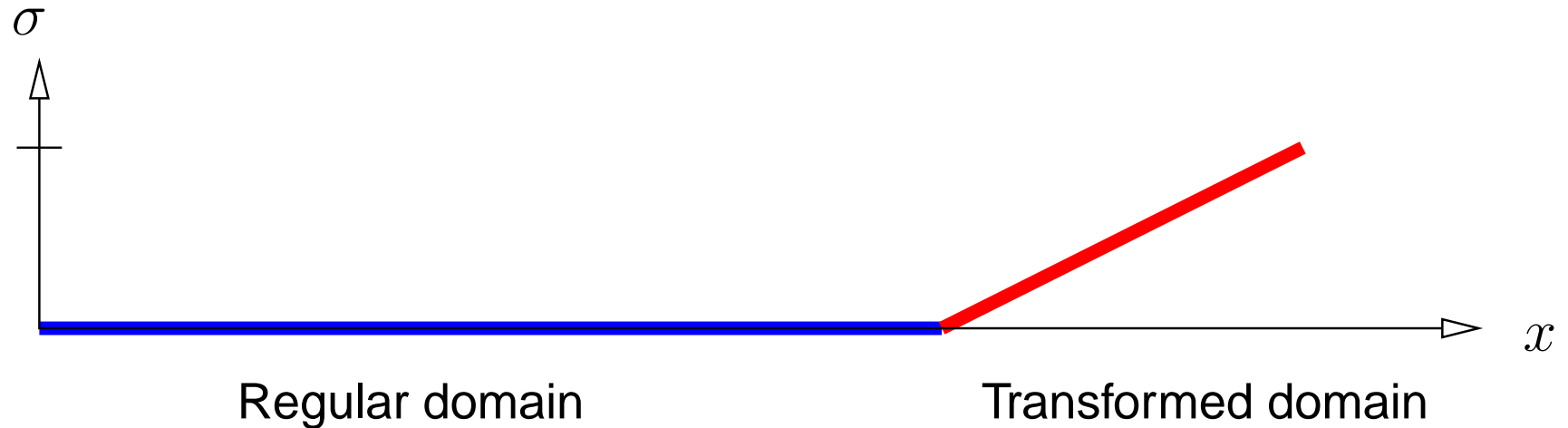


$$\frac{d\tilde{x}}{dx} = \lambda(x) \text{ where } \lambda(s) = 1 - i\sigma(s)$$

$$\frac{d^2 \hat{u}}{d\tilde{x}^2} + k^2 \hat{u} = 0$$

$$\hat{u} = c_{\text{out}} e^{-ik\tilde{x}} + c_{\text{in}} e^{ik\tilde{x}}$$

# 1-D model problem with PML

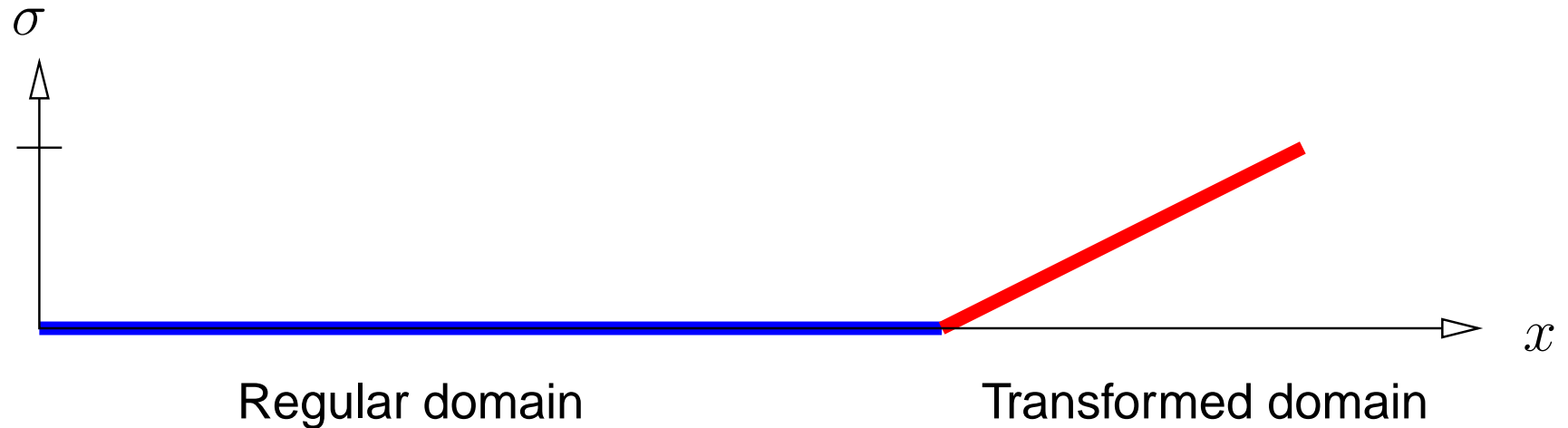


$$\frac{d\tilde{x}}{dx} = \lambda(x) \text{ where } \lambda(s) = 1 - i\sigma(s)$$

$$\frac{1}{\lambda} \frac{d}{dx} \left( \frac{1}{\lambda} \frac{d\hat{u}}{dx} \right) + k^2 \hat{u} = 0$$

$$\hat{u} = c_{\text{out}} \exp \left( -k \int_0^x \sigma(s) ds \right) e^{-ikx} + c_{\text{in}} \exp \left( k \int_0^x \sigma(s) ds \right) e^{ikx}$$

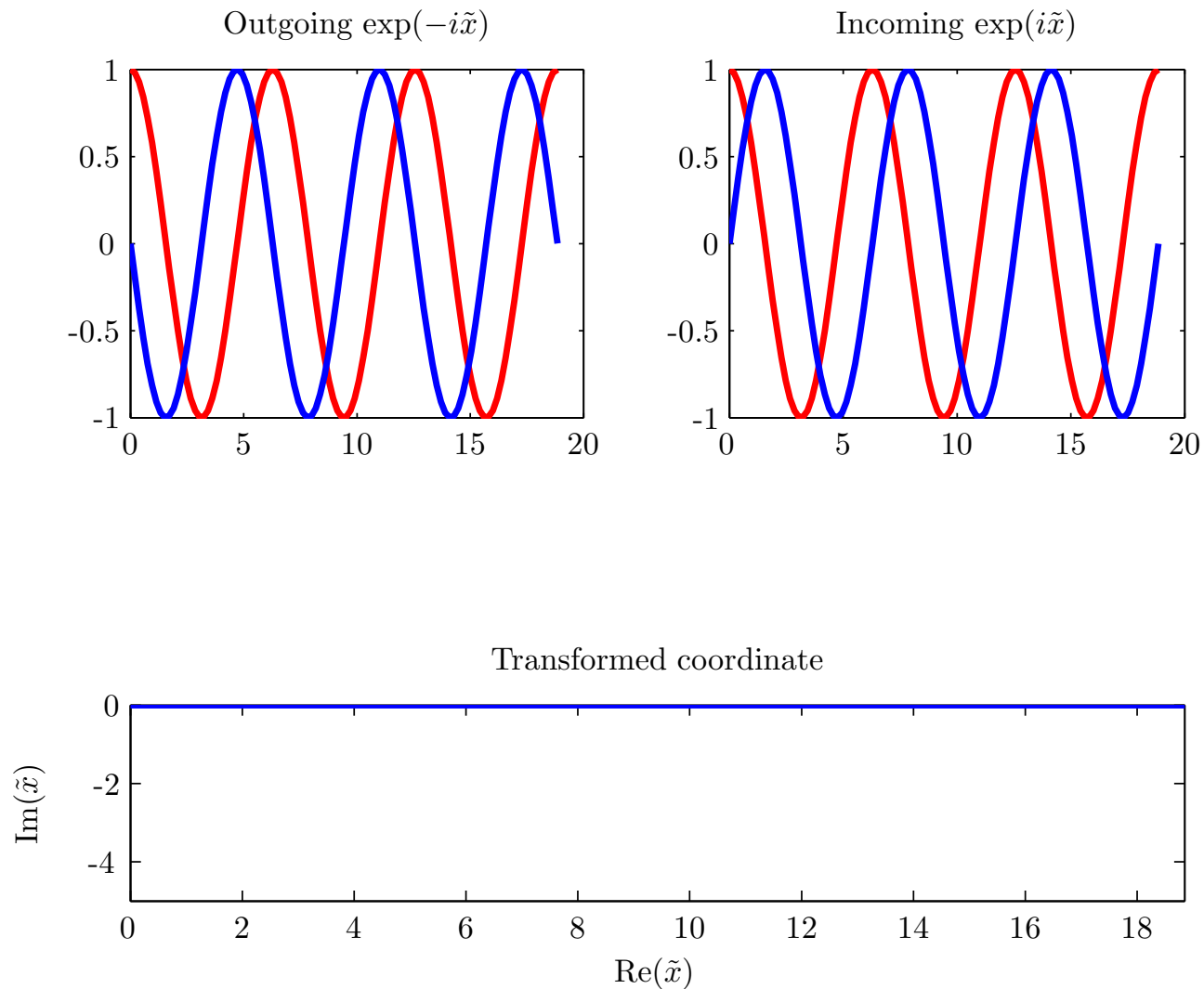
# 1-D model problem with PML



If solution clamped at  $x = L$  then

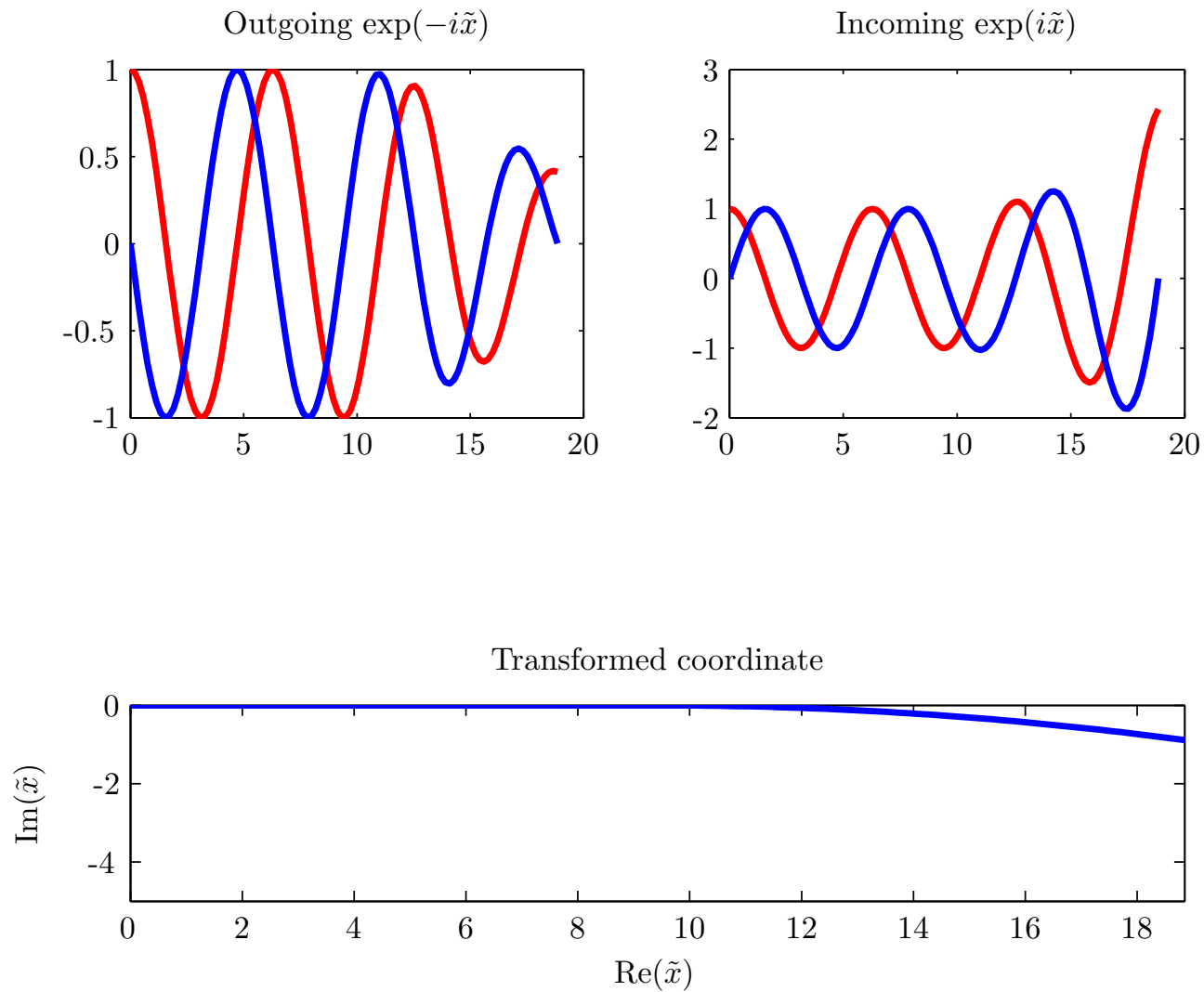
$$\frac{c_{\text{in}}}{c_{\text{out}}} = O(e^{-k\gamma}) \text{ where } \gamma = \int_0^L \sigma(s) ds$$

# 1-D model problem illustrated

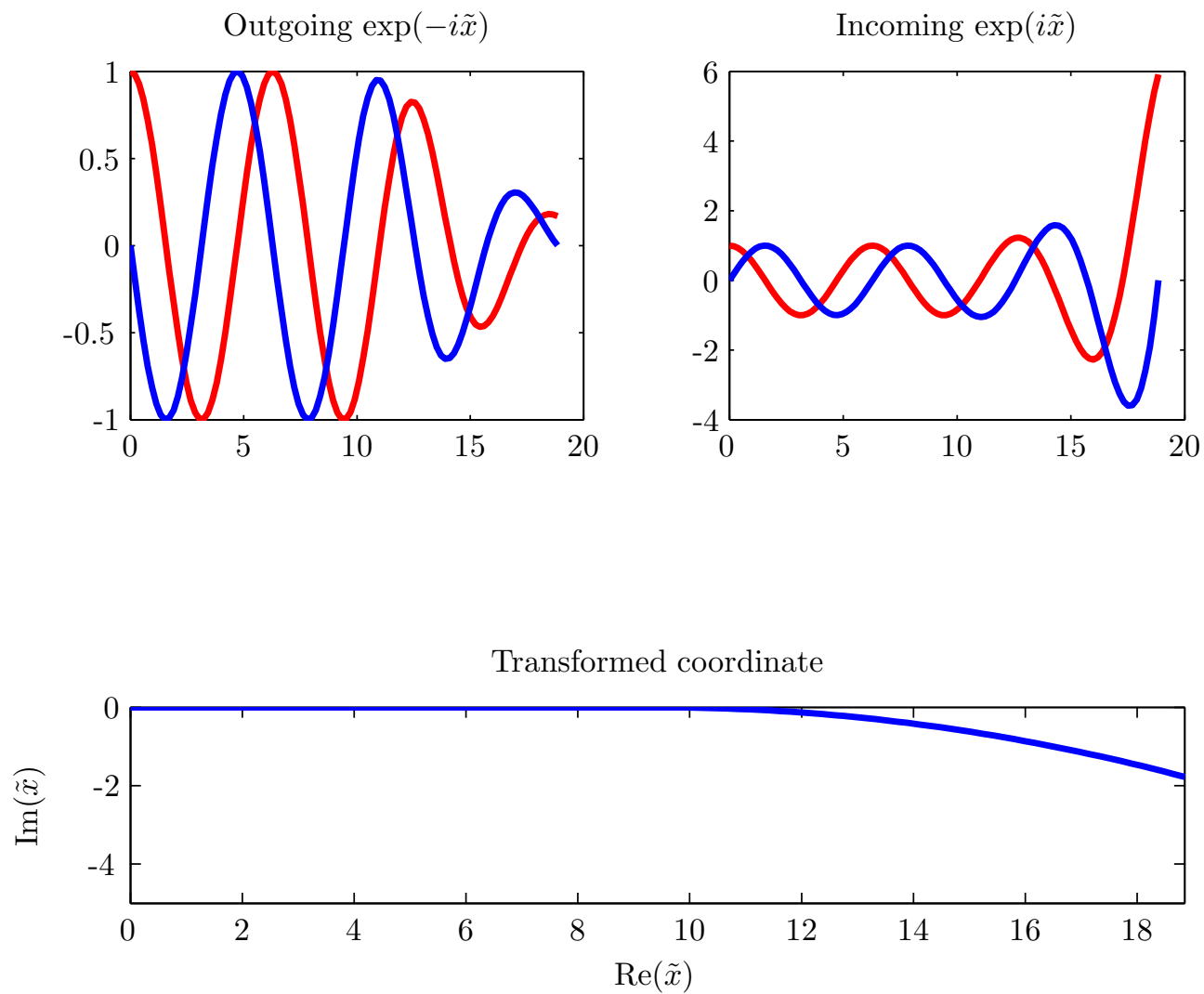




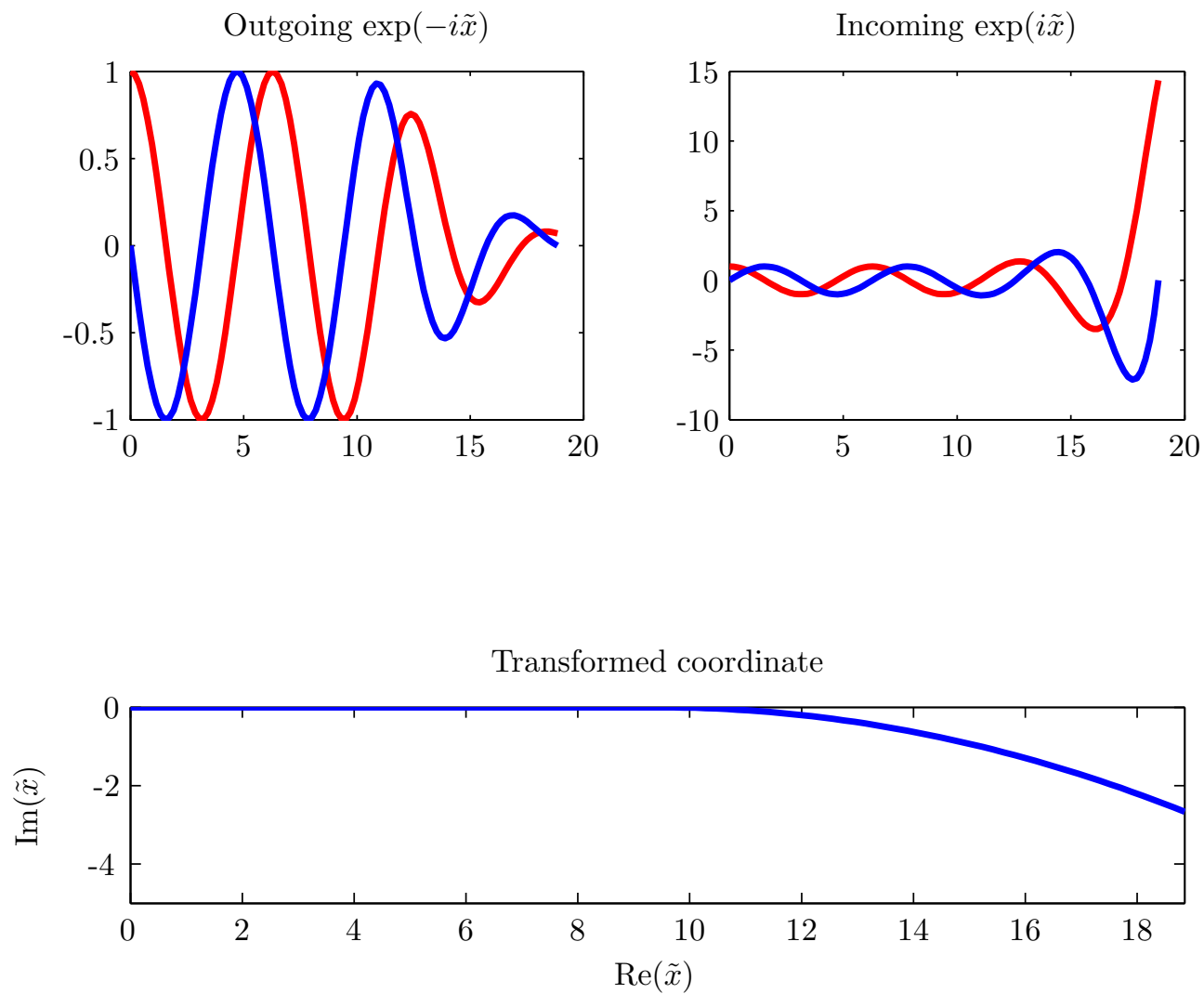
# 1-D model problem illustrated



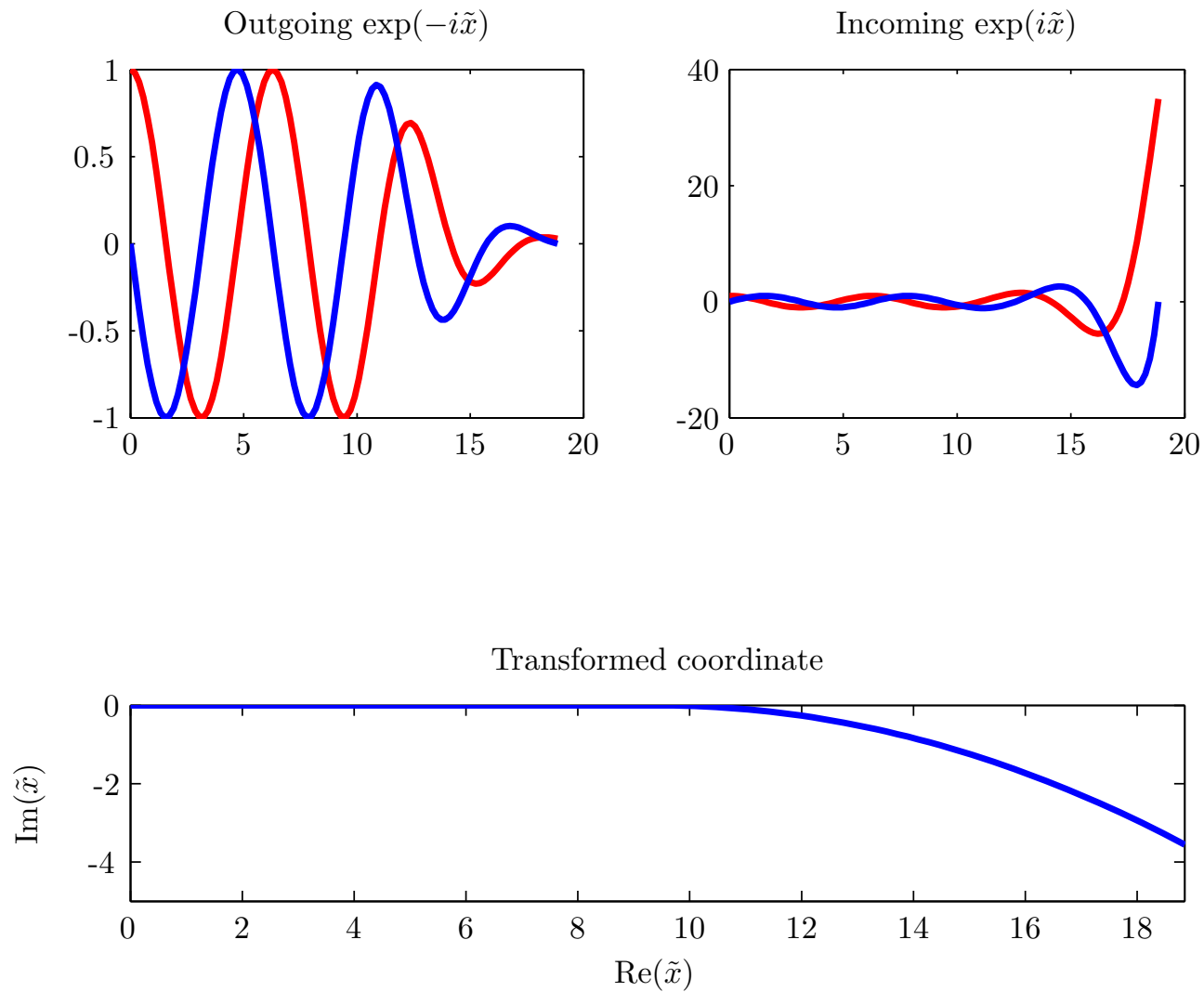
# 1-D model problem illustrated



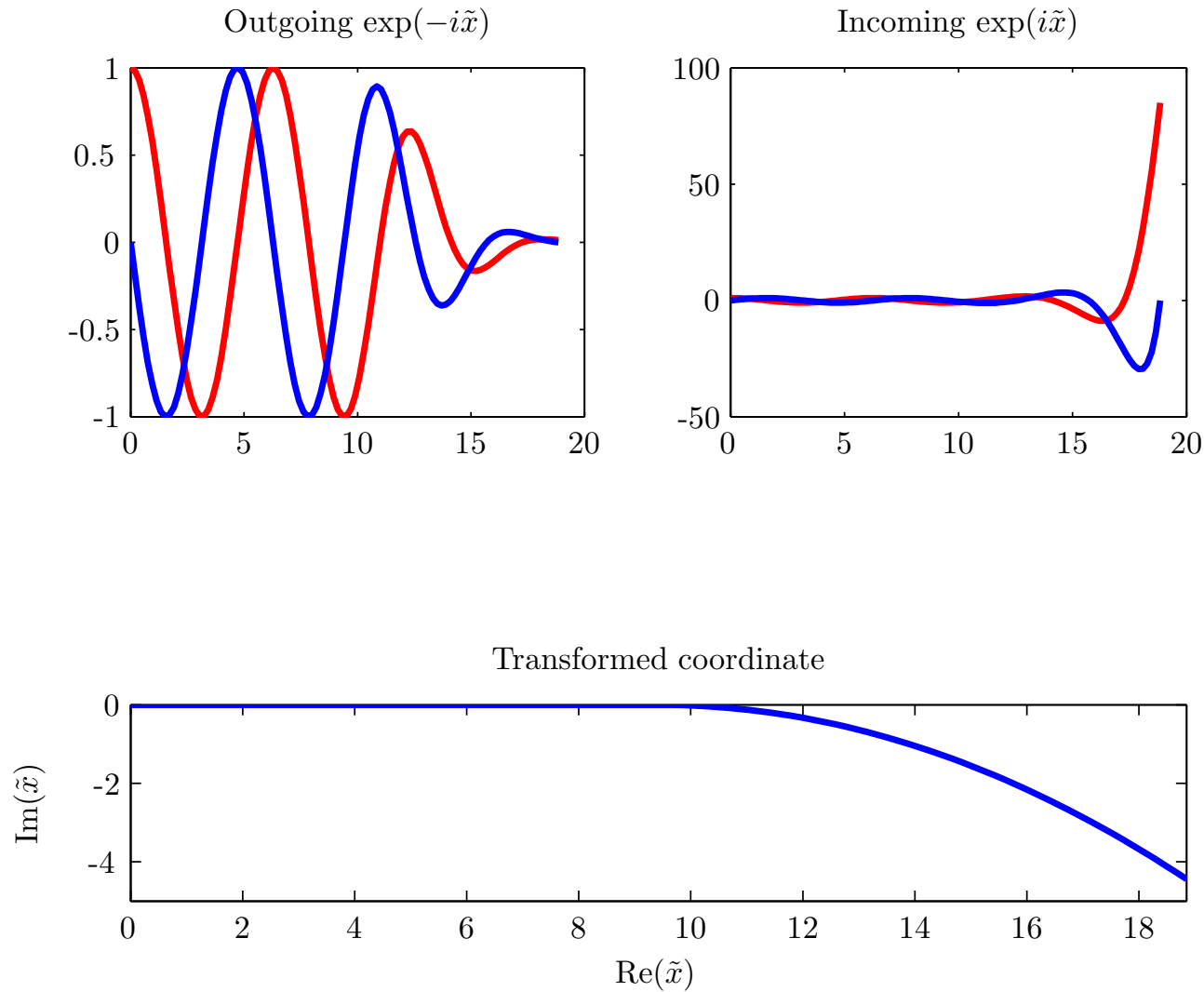
# 1-D model problem illustrated



# 1-D model problem illustrated



# 1-D model problem illustrated



Clamp solution at transformed end to isolate outgoing wave.

# Elastic PMLs

$$\int_{\Omega} \epsilon(w) : \mathbb{C} : \epsilon(u) d\Omega - \omega^2 \int_{\Omega} \rho w \cdot u d\Omega = \int_{\Gamma} w \cdot t_n d\Gamma$$

$$\epsilon(u) = \left( \frac{\partial u}{\partial x} \right)^s$$

- Start from standard weak form

# Elastic PMLs

$$\int_{\tilde{\Omega}} \tilde{\epsilon}(w) : \mathbb{C} : \tilde{\epsilon}(u) d\tilde{\Omega} - \omega^2 \int_{\tilde{\Omega}} \rho w \cdot u d\tilde{\Omega} = \int_{\Gamma} w \cdot t_n d\Gamma$$

$$\tilde{\epsilon}(u) = \left( \frac{\partial u}{\partial \tilde{x}} \right)^s = \left( \frac{\partial u}{\partial x} \Lambda^{-1} \right)^s$$

- Start from standard weak form
- Introduce transformed  $\tilde{x}$  with  $\frac{\partial \tilde{x}}{\partial x} = \Lambda$

# Elastic PMLs

$$\int_{\Omega} \tilde{\epsilon}(w) : \mathbb{C} : \tilde{\epsilon}(u) J_{\Lambda} d\Omega - \omega^2 \int_{\Omega} \rho w \cdot u J_{\Lambda} d\Omega = \int_{\Gamma} w \cdot t_n d\Gamma$$

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- Start from standard weak form
- Introduce transformed  $\tilde{x}$  with  $\frac{\partial \tilde{x}}{\partial x} = \Lambda$
- Map back to reference system ( $J_{\Lambda} = \det(\Lambda)$ )



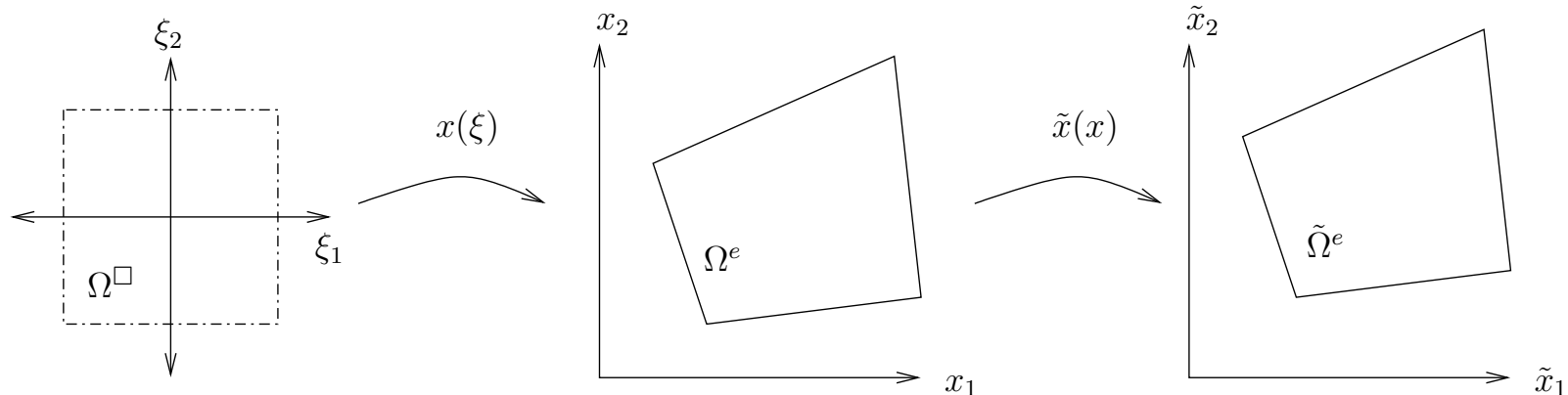
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- Start from standard weak form
- Introduce transformed  $\tilde{x}$  with  $\frac{\partial \tilde{x}}{\partial x} = \Lambda$
- Map back to reference system ( $J_{\Lambda} = \det(\Lambda)$ )
- All terms are symmetric in  $w$  and  $u$

# Finite element implementation



- Combine PML and isoparametric mappings

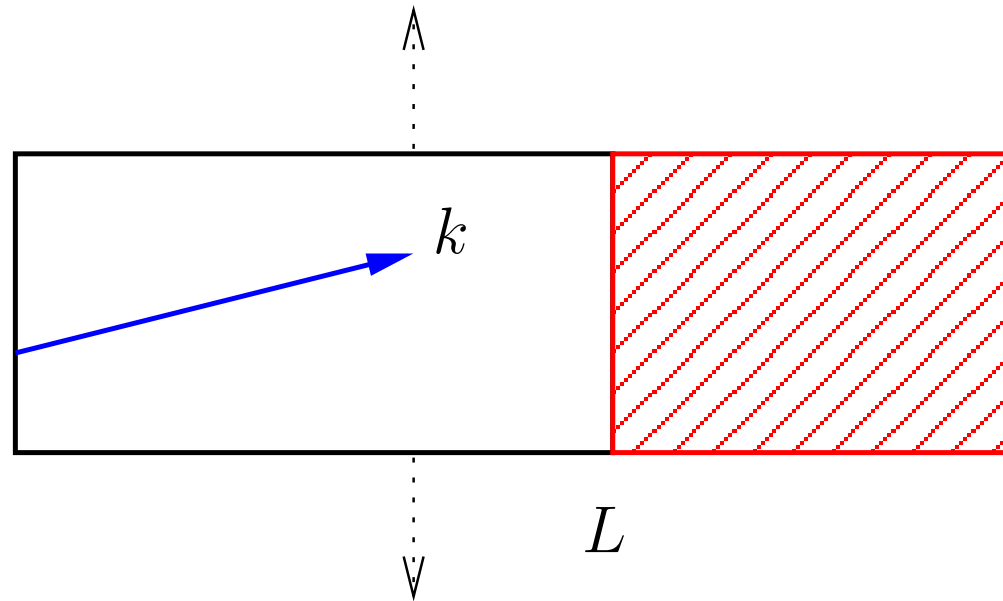
$$\mathbf{k}^e = \int_{\Omega^\square} \tilde{\mathbf{B}}^T \mathbf{D} \tilde{\mathbf{B}} \tilde{J} d\Omega^\square$$
$$\mathbf{m}^e = \left( \int_{\Omega^\square} \rho \mathbf{N}^T \mathbf{N} \tilde{J} d\Omega^\square \right)$$

- Matrices are *complex symmetric*

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  - A two-dimensional model problem
  - Analysis of discrete reflection
  - Choice of PML parameters
- Complex symmetry and structured model reduction
- Analysis of a disk resonator
- Conclusions

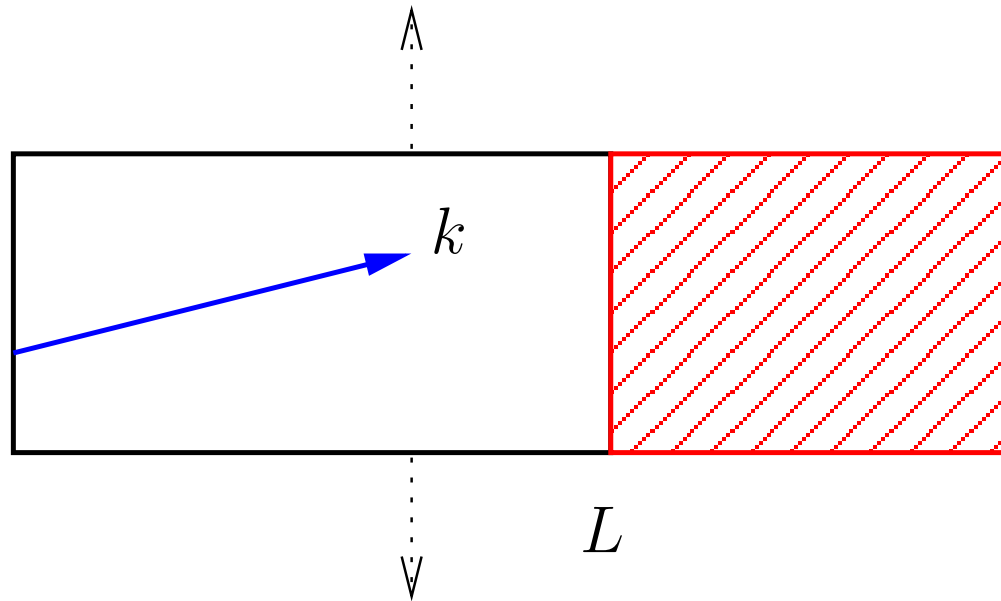
# Continuum 2D model problem



$$\lambda(x) = \begin{cases} 1 - i\beta|x - L|^p, & x > L \\ 1 & x \leq L. \end{cases}$$

$$\frac{1}{\lambda} \frac{\partial}{\partial x} \left( \frac{1}{\lambda} \frac{\partial u}{\partial x} \right) + \frac{\partial^2 u}{\partial y^2} + k^2 u = 0$$

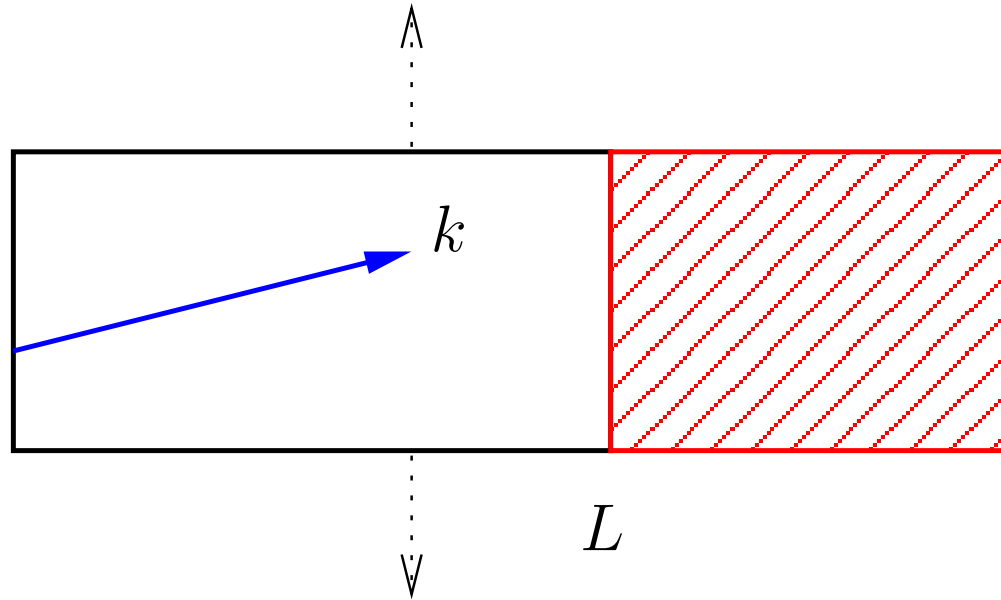
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$$\frac{1}{\lambda} \frac{\partial}{\partial x} \left( \frac{1}{\lambda} \frac{\partial u}{\partial x} \right) - k_y^2 u + k^2 u = 0$$

# Continuum 2D model problem

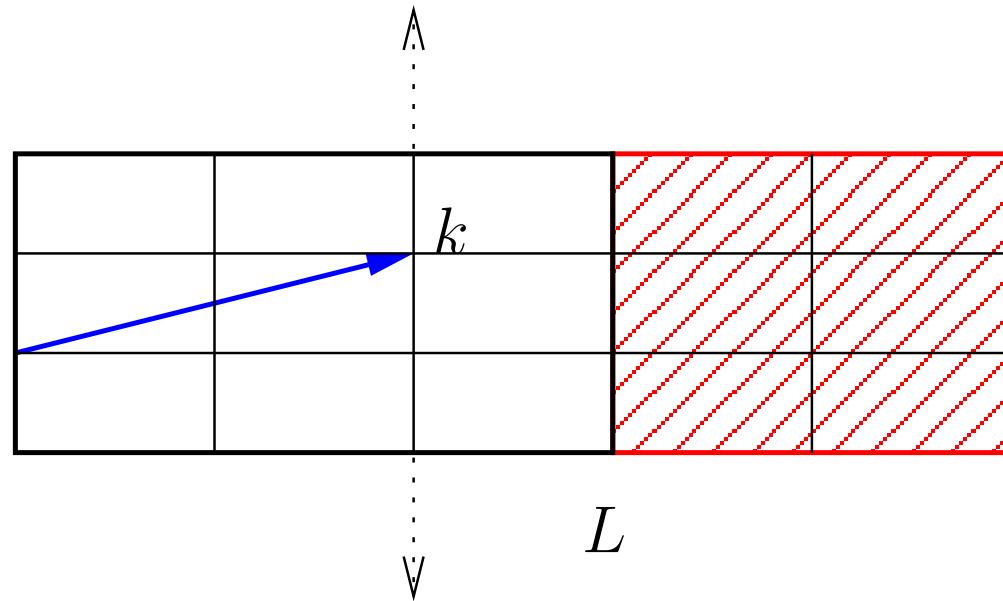


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$$\frac{1}{\lambda} \frac{\partial}{\partial x} \left( \frac{1}{\lambda} \frac{\partial u}{\partial x} \right) + k_x^2 u = 0$$

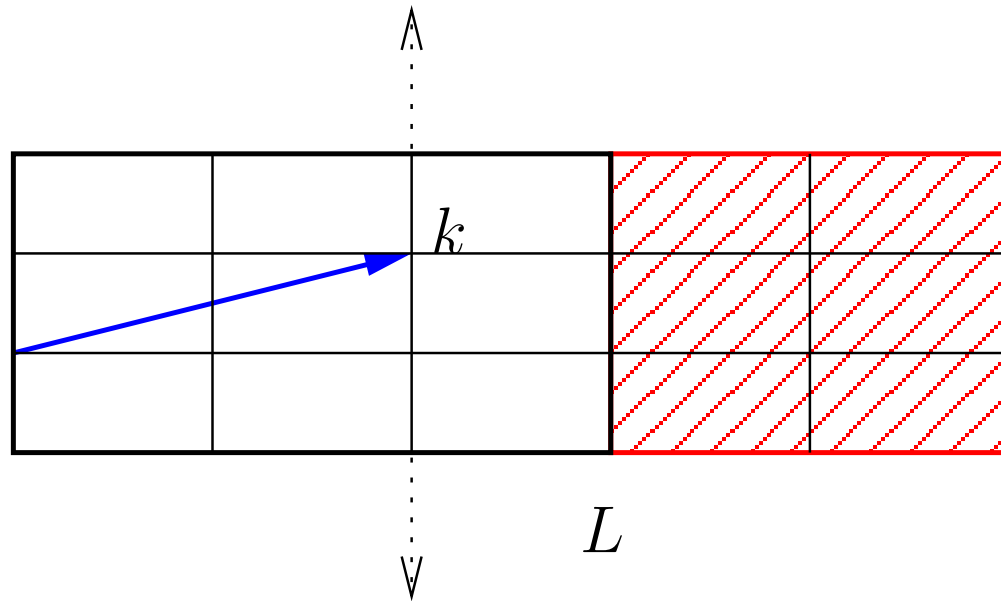
1D problem, reflection of  $O(e^{-k_x \gamma})$

# Discrete 2D model problem



- Discrete Fourier transform in  $y$
- Solve numerically in  $x$
- Project solution onto infinite space traveling modes
- Extension of Collino and Monk (1998)

# Nondimensionalization



$$\lambda(x) = \begin{cases} 1 - i\beta|x - L|^p, & x > L \\ 1 & x \leq L. \end{cases}$$

Rate of stretching:

$$\beta h^p$$

Elements per wave:

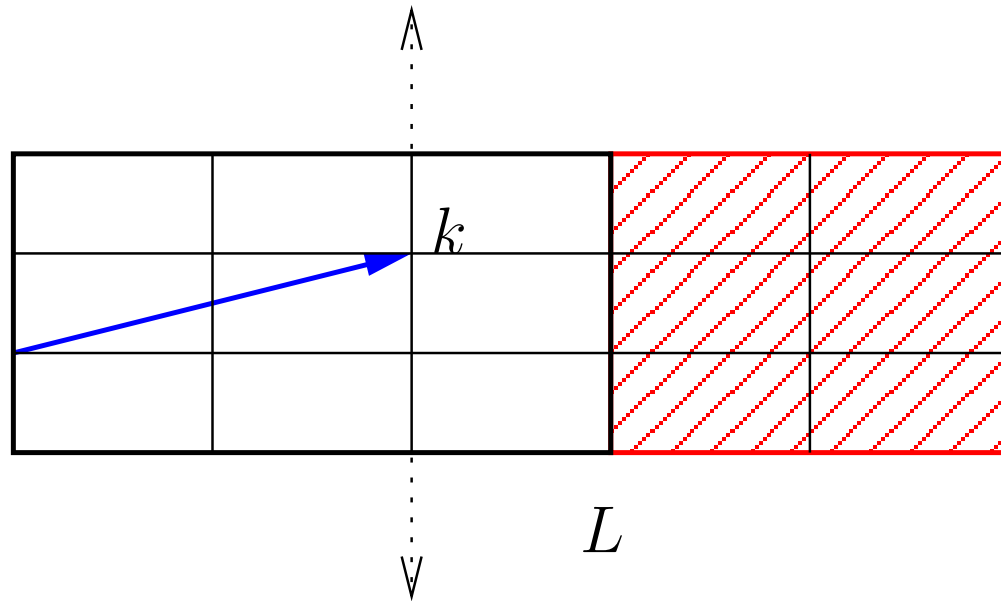
$$(k_x h)^{-1} \text{ and } (k_y h)^{-1}$$

Elements through the PML:

$$N$$



# Nondimensionalization



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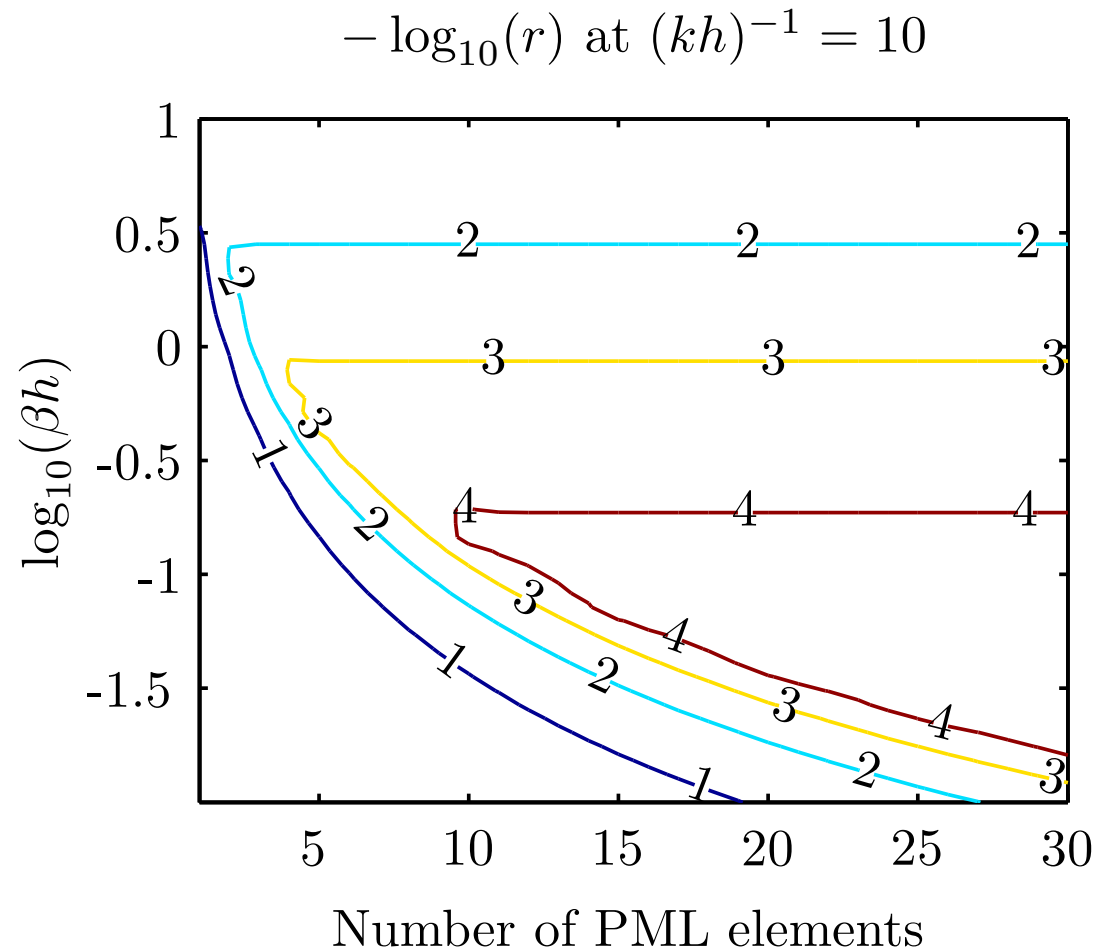
$$\beta h^p$$

Elements per wave:

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Elements through the PML:  $N$

# Discrete reflection behavior



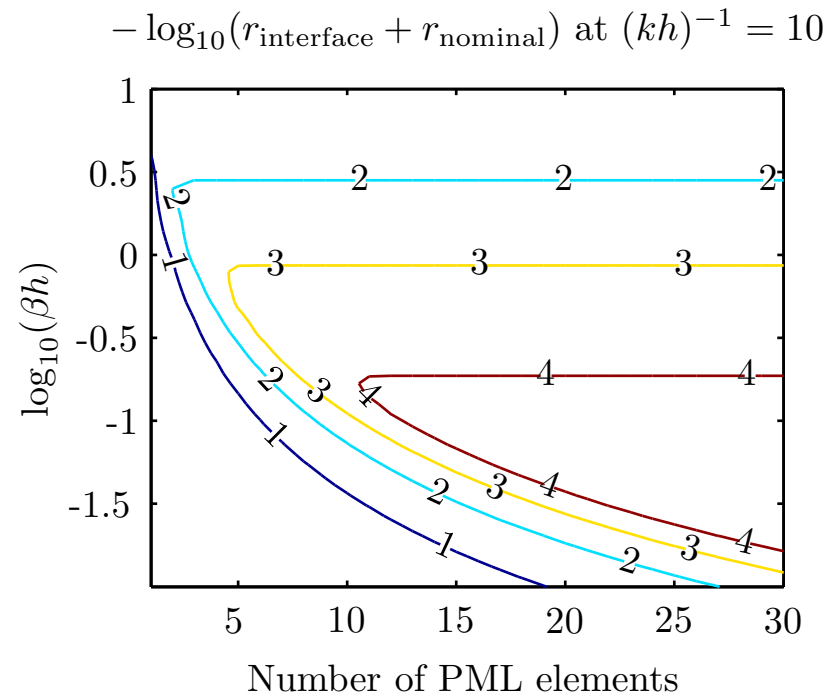
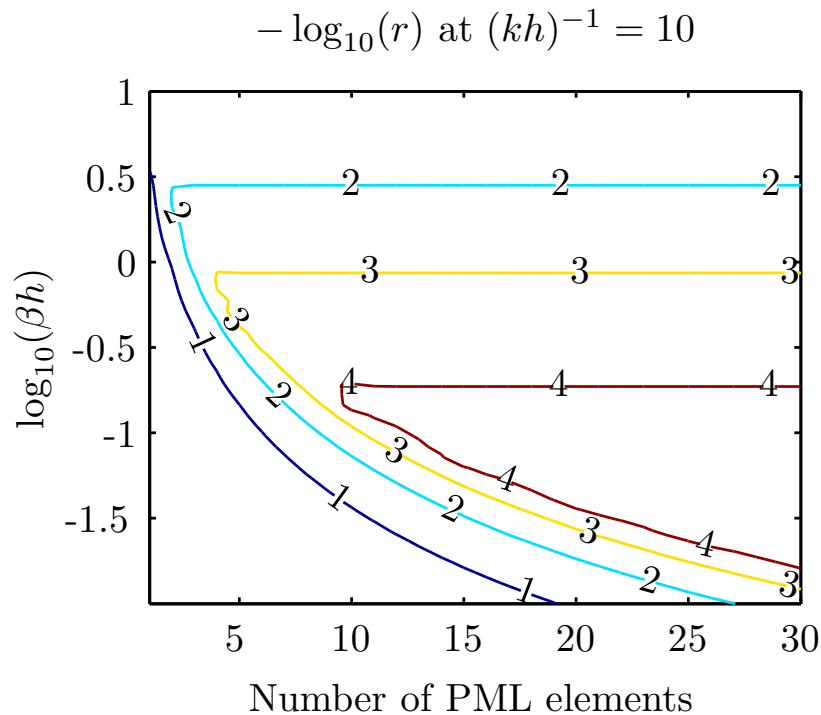
Quadratic elements,  $p = 1$ ,  $(k_x h)^{-1} = 10$

# Discrete reflection decomposition

Model discrete reflection as two parts:

- Far-end reflection (clamping reflection)
  - Approximated well by continuum calculation
  - Grows as  $(k_x h)^{-1}$  grows
- Interface reflection
  - Discrete effect: mesh does not resolve decay
  - Does not depend on  $N$
  - Grows as  $(k_x h)^{-1}$  shrinks

# Discrete reflection behavior



Quadratic elements,  $p = 1$ ,  $(k_x h)^{-1} = 10$

- Model does well at predicting actual reflection
- Similar picture for other wavelengths, element types, stretch functions

# Choosing PML parameters

- Discrete reflection dominated by
  - Interface reflection when  $k_x$  large
  - Far-end reflection when  $k_x$  small
- Heuristic for PML parameter choice
  - Choose an acceptable reflection level
  - Choose  $\beta$  based on interface reflection at  $k_x^{\max}$
  - Choose length based on far-end reflection at  $k_x^{\min}$

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- Complex symmetry and structured model reduction
  - Krylov subspace projections
  - Structure-preserving eigencomputations
  - Structure-preserving model reduction
- Analysis of a disk resonator
- Conclusions

# Eigenvalues and model reduction

Want to know about the transfer function  $H(\omega)$ :

$$H(\omega) = p^T (K - \omega^2 M)^{-1} b$$

Can either

- Locate poles of  $H$  (eigenvalues of  $(K, M)$ )
  - Determine  $Q = \frac{|\omega|}{2 \operatorname{Im}(\omega)}$
- Plot  $H$  in a frequency range (Bode plot)

Solve both problems with the same tool:

**Krylov subspace projections**

# Projecting via Arnoldi

Build a Krylov subspace basis by shift-invert Arnoldi

- Choose shift  $\sigma$  in frequency range of interest
- Form and factor  $K_{\text{shift}} = K - \sigma^2 M$
- Use Arnoldi to build an orthonormal basis  $V$  for

$$\mathcal{K}_n = \text{span}\{u_0, K_{\text{shift}}^{-1}u_0, \dots, K_{\text{shift}}^{-(n-1)}u_0\}$$

Compute eigenvalues and reduced models from projection

- Compute eigenvalues from  $(V^*KV, V^*MV)$
- Approximate  $H(\omega)$  by Galerkin projection

$$H(\omega) \approx (V^*p)^*(V^*KV - \omega^2 V^*MV)^{-1}(V^*b)$$



# Accurate eigenvalues

- *Hermitian* systems: Rayleigh-Ritz is optimal
  - Raleigh quotient is stationary at eigenvectors

$$\rho(v) = \frac{v^* K v}{v^* M v}$$

- First-order accurate eigenvectors  $\implies$  second-order accurate eigenvalues
- Can we obtain optimal accuracy for PML eigenvalues?

# Accurate eigenvalues

- PML matrices are *complex symmetric*
  - Modified RQ is stationary at eigenvectors

$$\theta(v) = \frac{v^T K v}{v^T M v}$$

- $\implies$  second-order accurate eigenvalues
- Hochstenbach and Arbenz, 2004

# Accurate model reduction

- Accurate eigenvalues from  $v$  and  $\bar{v}$  together
- Accurate model reduction in the same way
  - Build new projection basis from  $V$ :

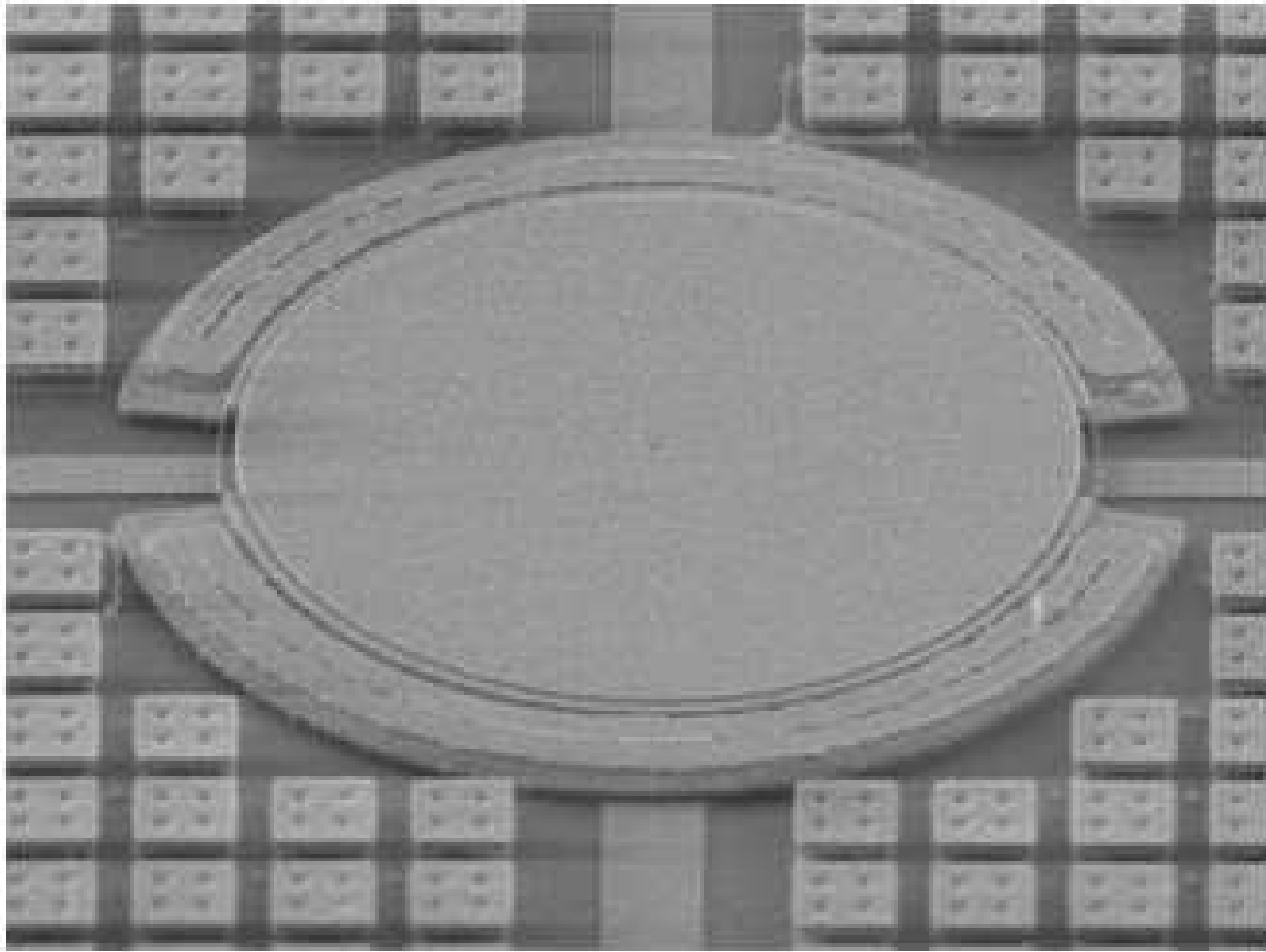
$$W = \text{orth}[\text{Re}(V), \text{Im}(V)]$$

- $\text{span}(W)$  contains both  $\mathcal{K}_n$  and  $\bar{\mathcal{K}}_n$ 
  - Double convergence vs projection with  $V$
- $W$  is a real-valued basis
  - Projected system remains complex symmetric

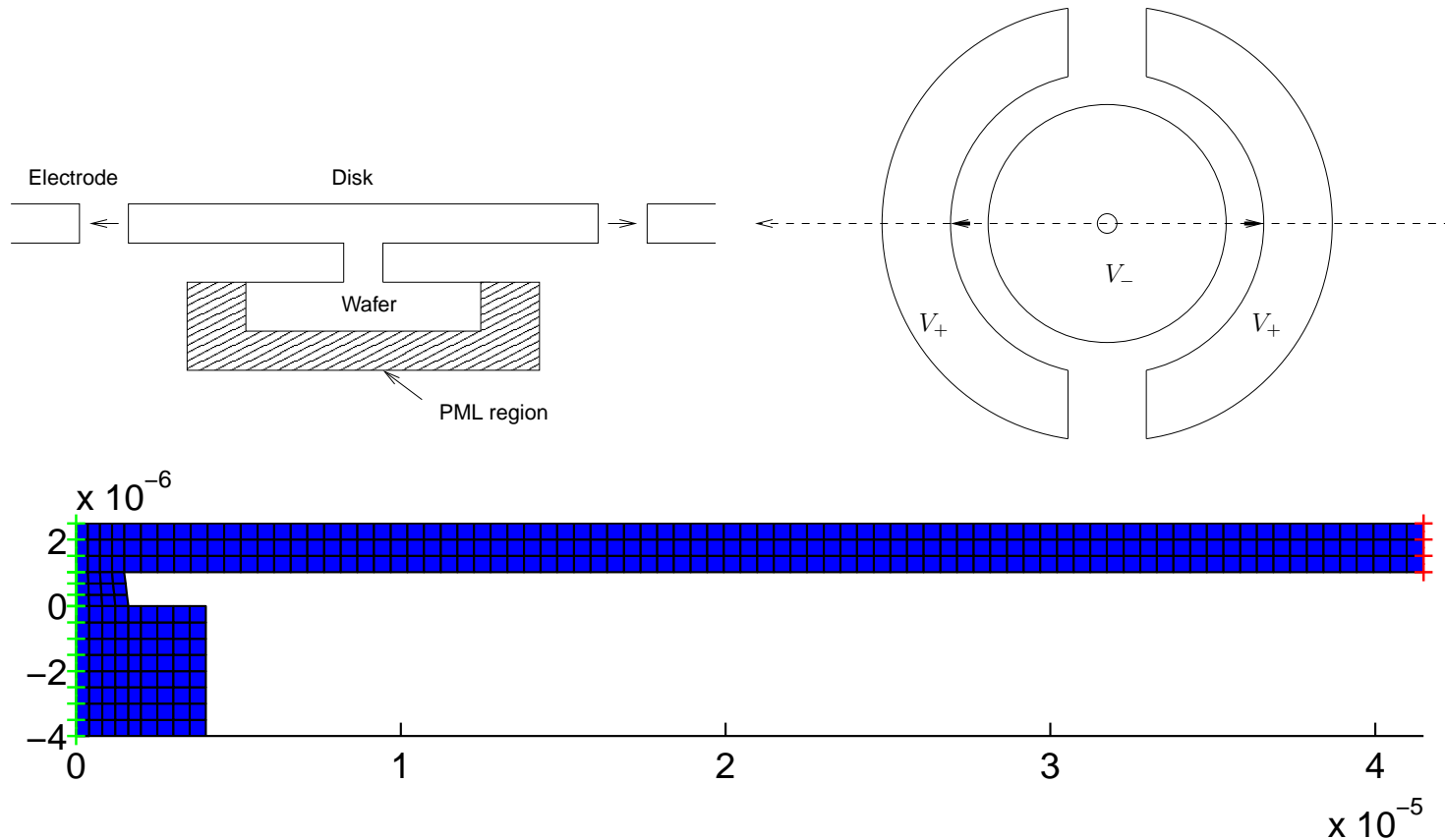
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  - Accuracy of the numerics
  - Description of the loss mechanism
  - Sensitivity to fabrication variations
- Conclusions

# Disk resonator simulations

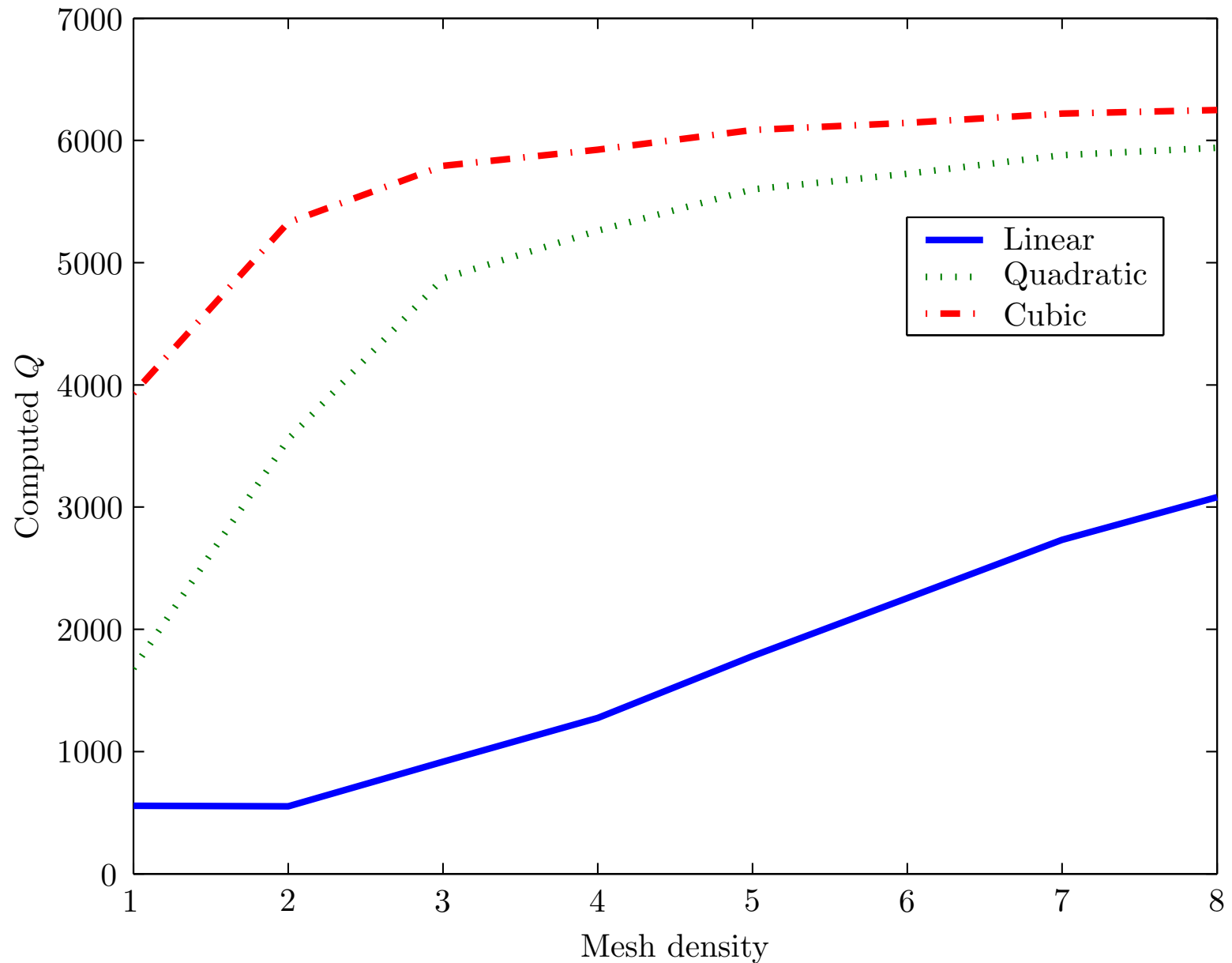


# Disk resonator mesh

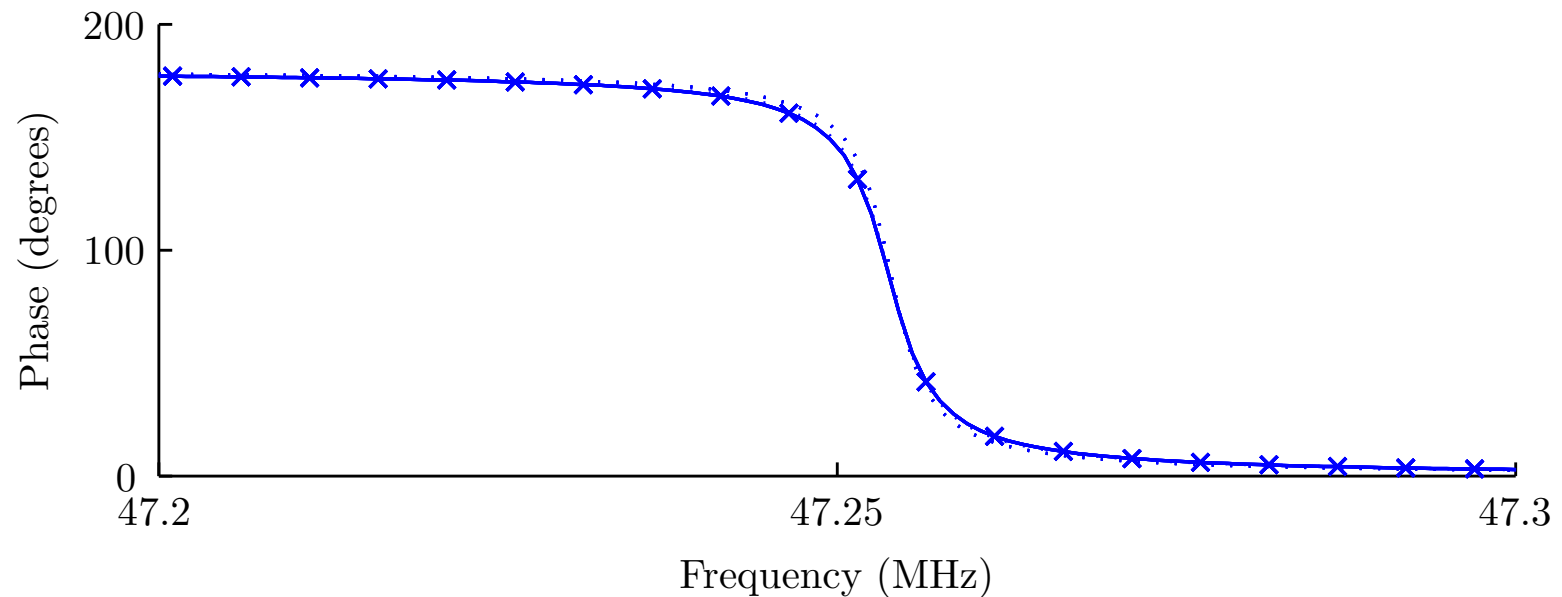
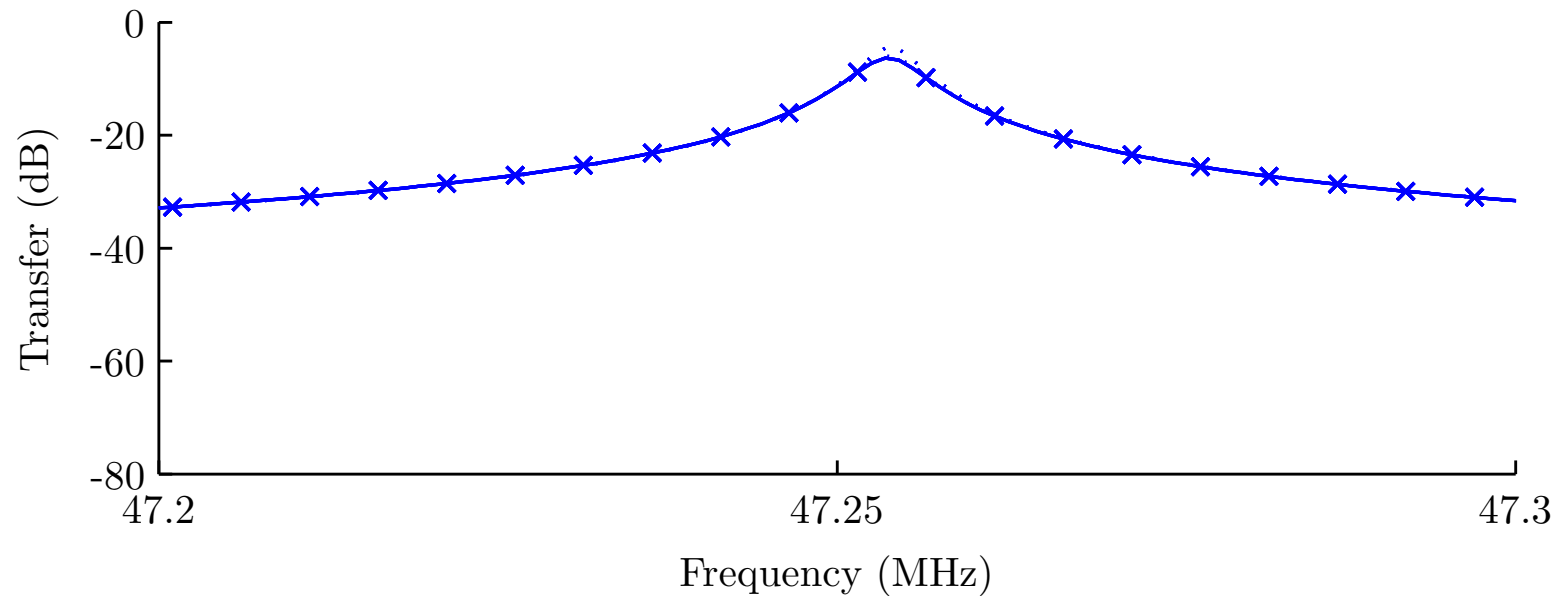


- Axisymmetric model with bicubic mesh
- About 10K nodal points in converged calculation

# Mesh convergence

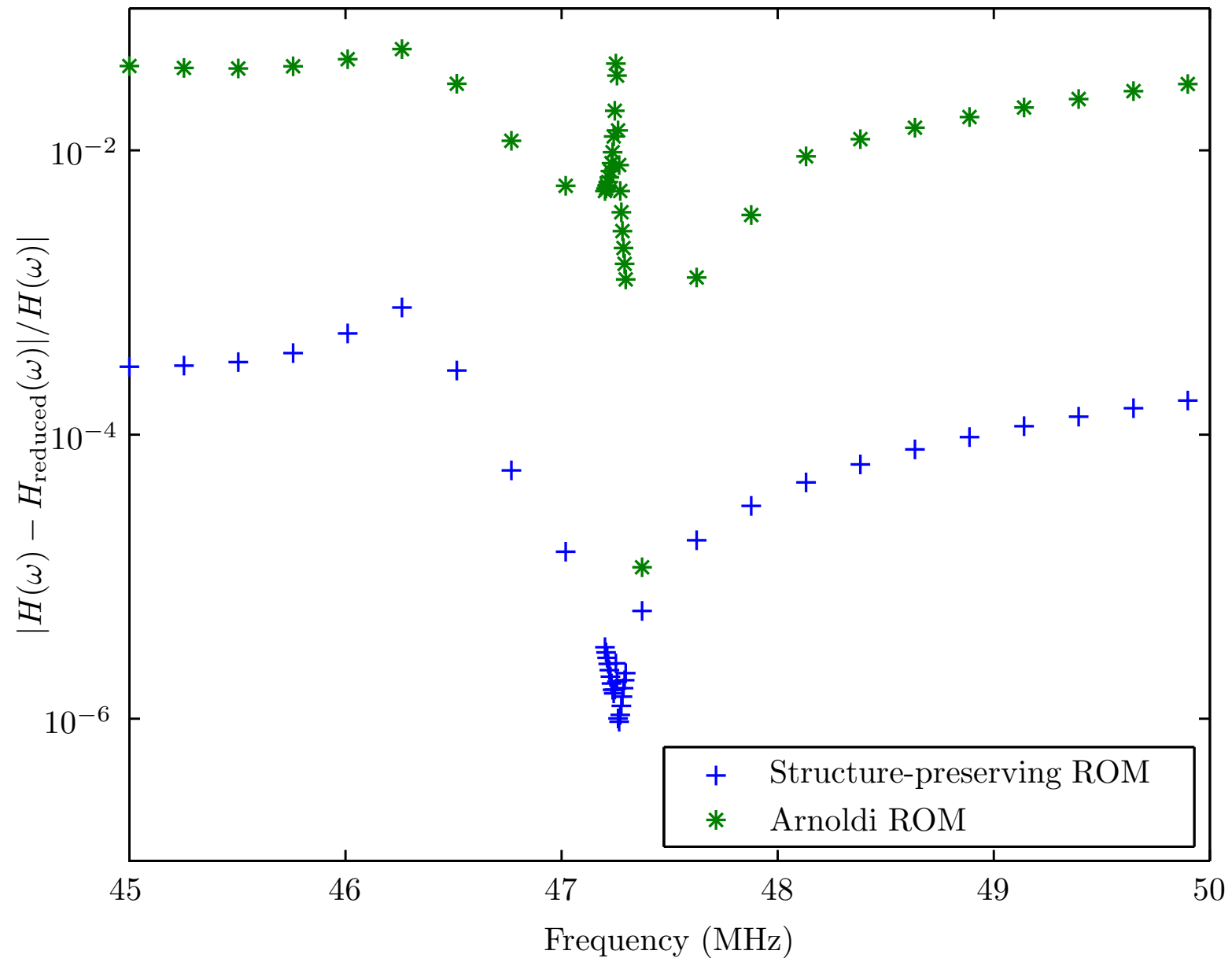


# Model reduction performance

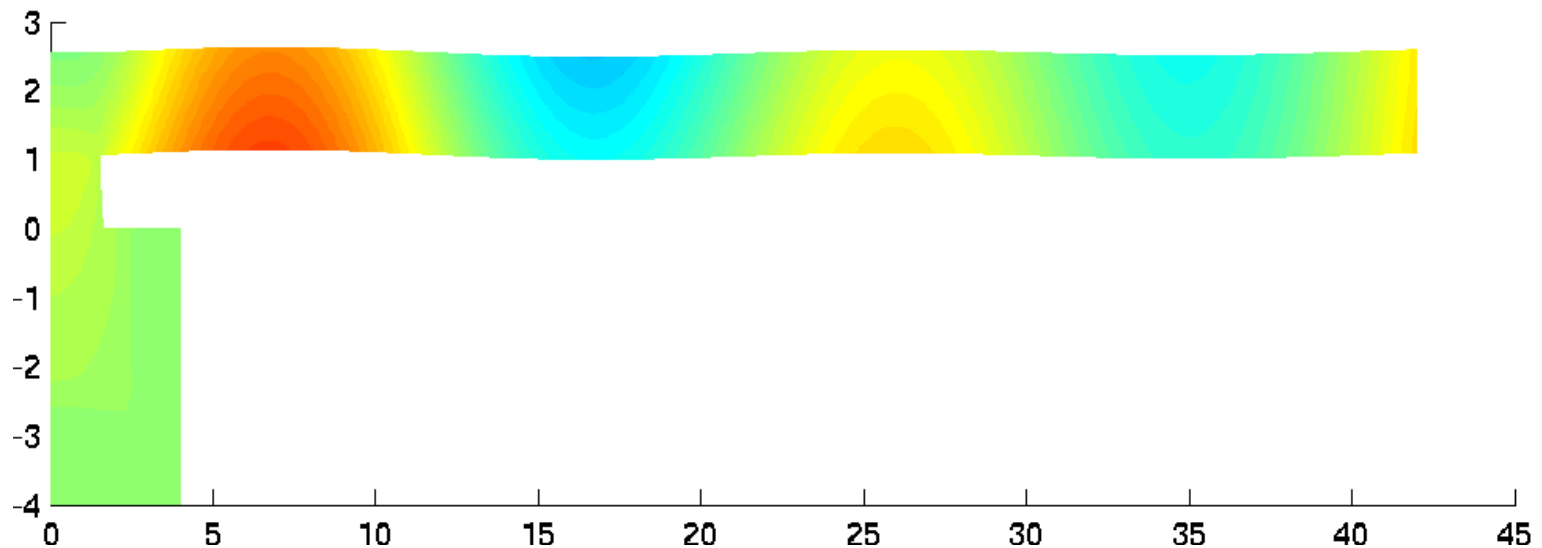
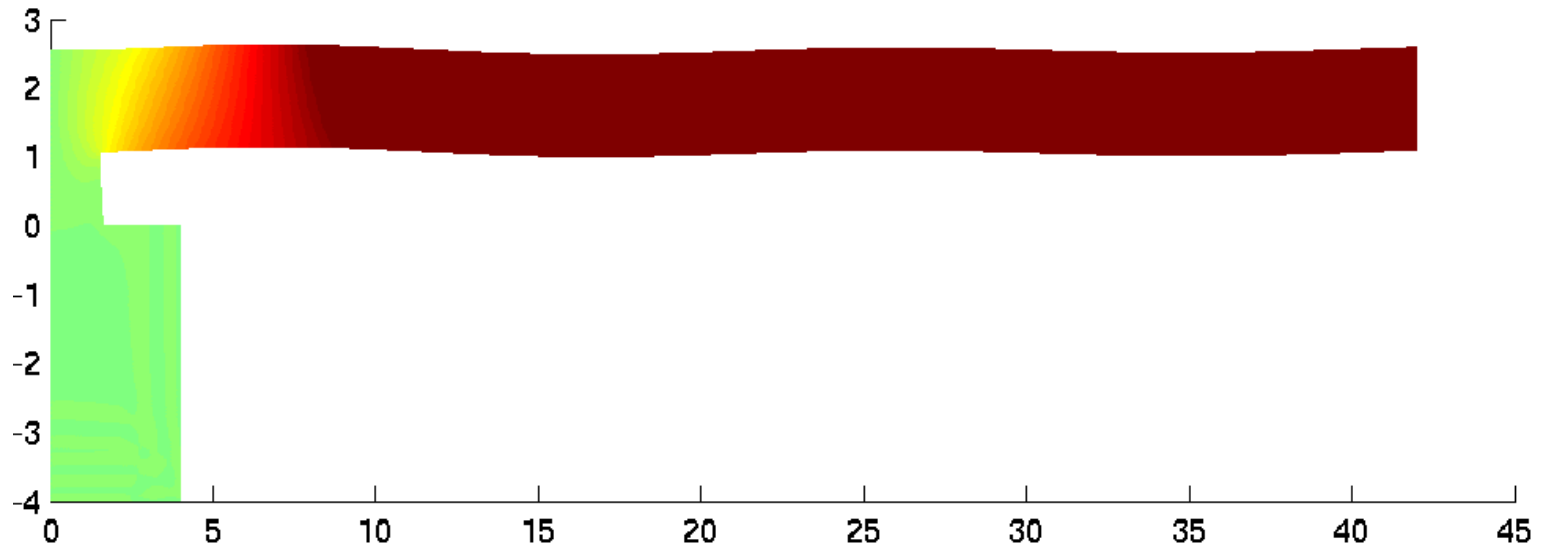




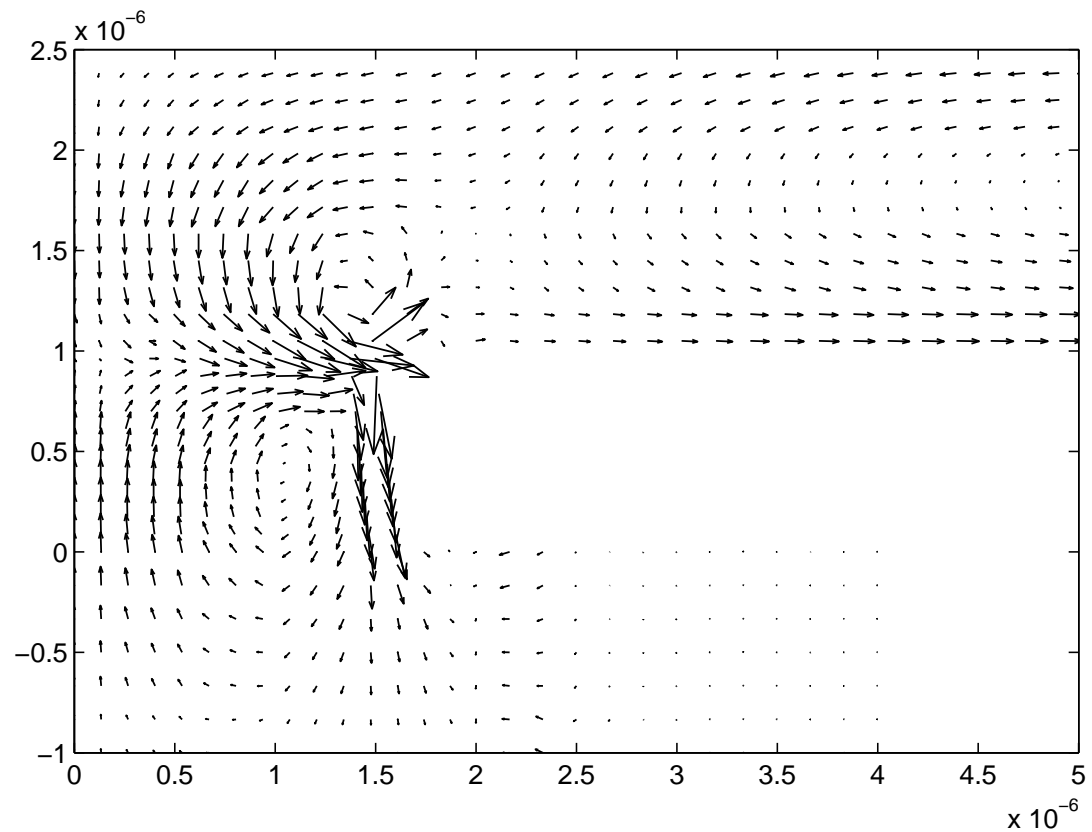
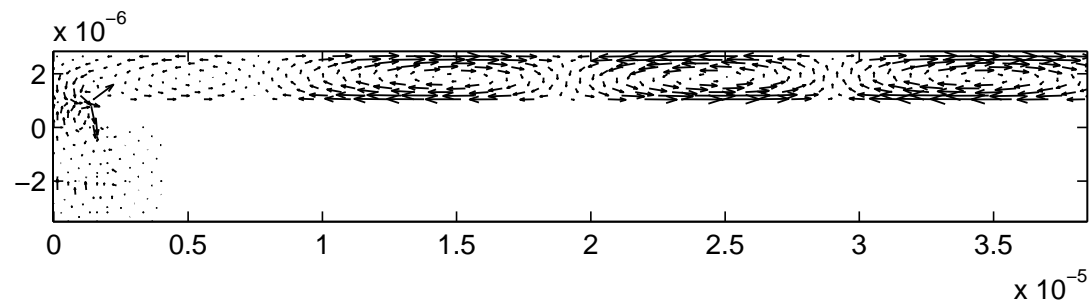
# Model reduction performance



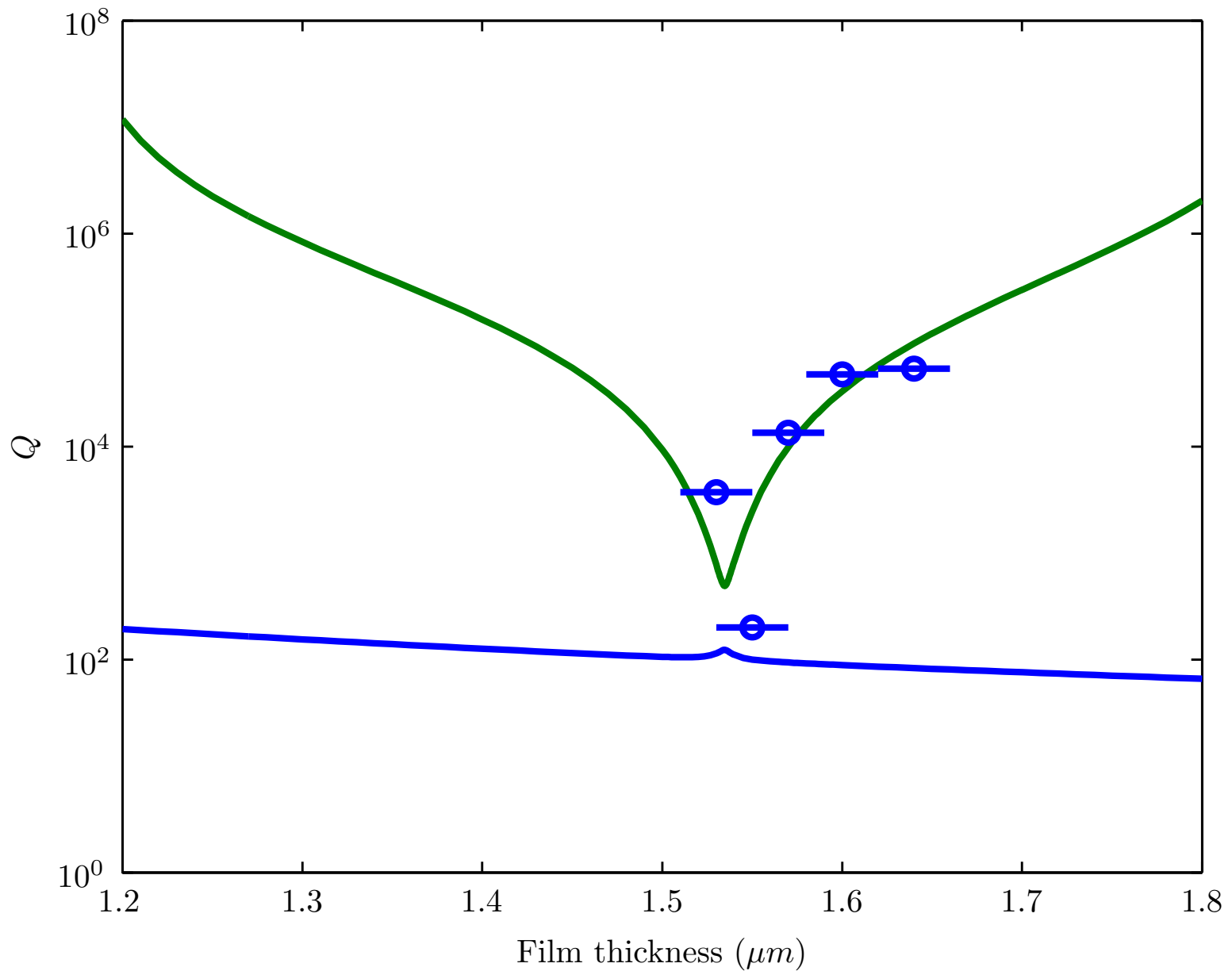
# Response of the disk resonator



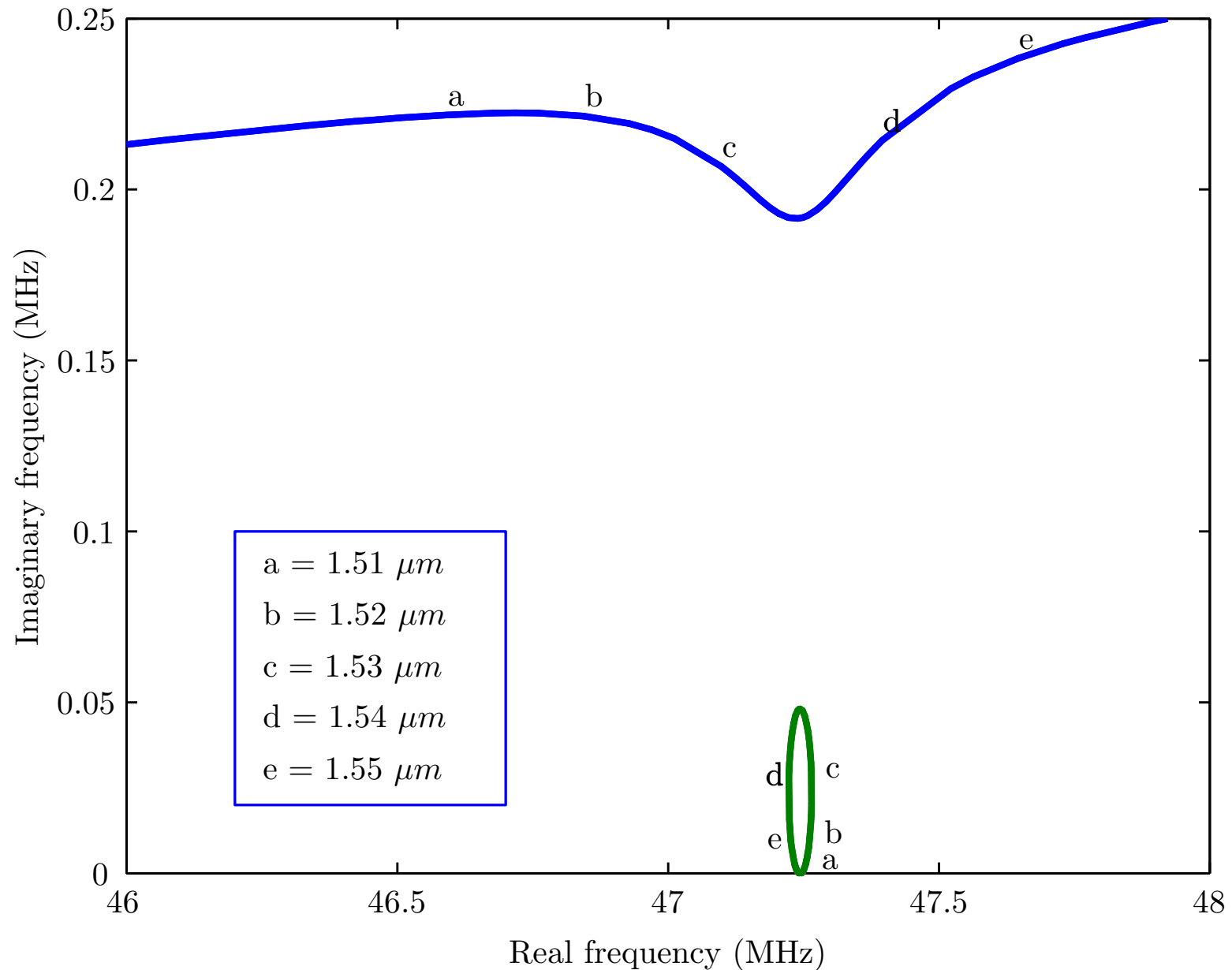
# Time-averaged energy flux



# $Q$ variation



# Explanation of $Q$ variation



# Conclusions

- MEMS damping is important and non-trivial
- Elastic PMLs work well for modeling anchor loss
  - Formulation fits naturally with mapped elements
  - Estimate multi-D performance with simple models
- Use complex symmetry to compute eigenvalues and reduced models
- Simulations show effects that hand analysis misses

## Reference:

Bindel and Govindjee, “Elastic PMLs for resonator anchor loss simulation,” *IJNME* (to appear).